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**Etzkorn et al.**

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(54) **FABRICATION METHODS FOR BIO-COMPATIBLE DEVICES**  
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(73) Assignee: **Verily Life Sciences LLC**, Mountain View, CA (US)

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**H01P 11/00** (2006.01)  
**H01Q 1/22** (2006.01)

(57) **ABSTRACT**

(52) **U.S. Cl.**  
CPC ..... **H01P 11/00** (2013.01); **H01Q 1/2216** (2013.01)

A method may involve: forming a first bio-compatible layer; forming a conductive pattern on the first bio-compatible layer, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects; forming a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer; mounting an electronic component to the electrical contacts; forming a second bio-compatible layer over the first bio-compatible layer, the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects; removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer; and removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes.

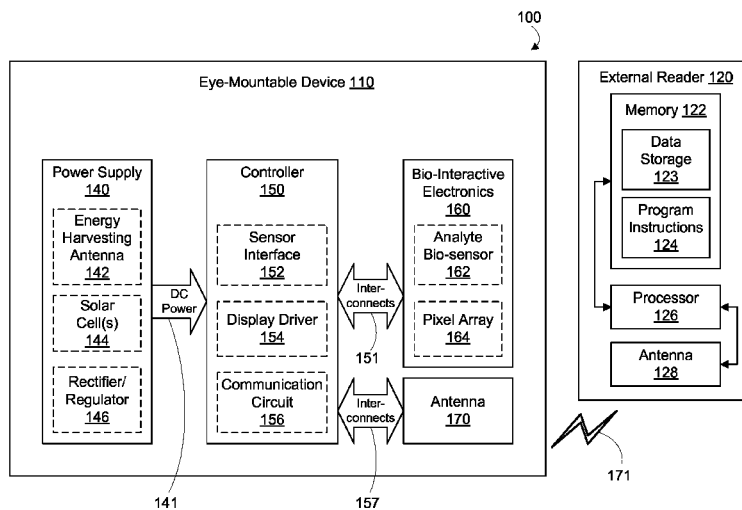
(58) **Field of Classification Search**  
CPC ..... G09G 5/00; G02C 7/04; G02C 11/00  
USPC ..... 343/720; 351/159  
See application file for complete search history.

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**20 Claims, 12 Drawing Sheets**



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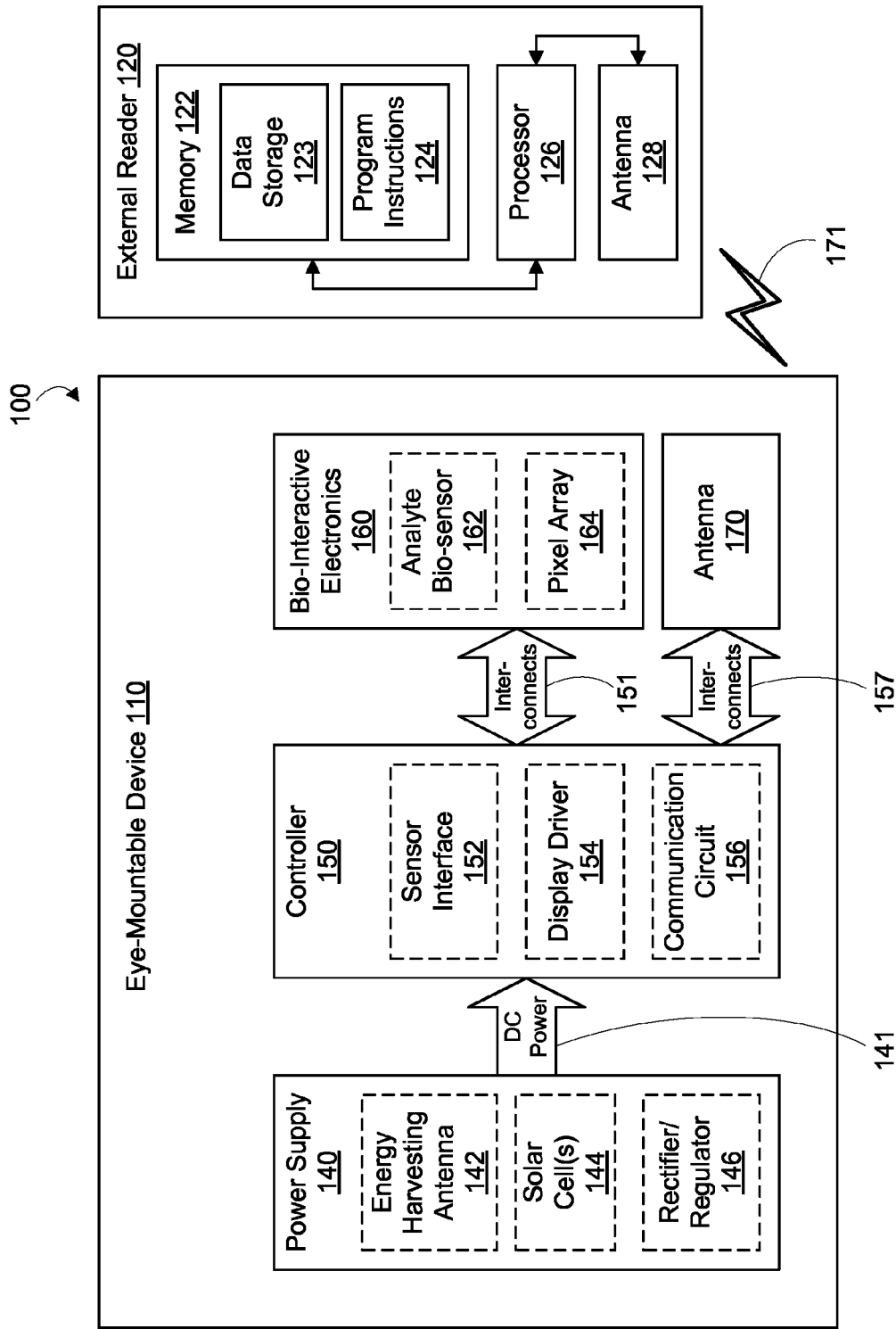


FIG. 1

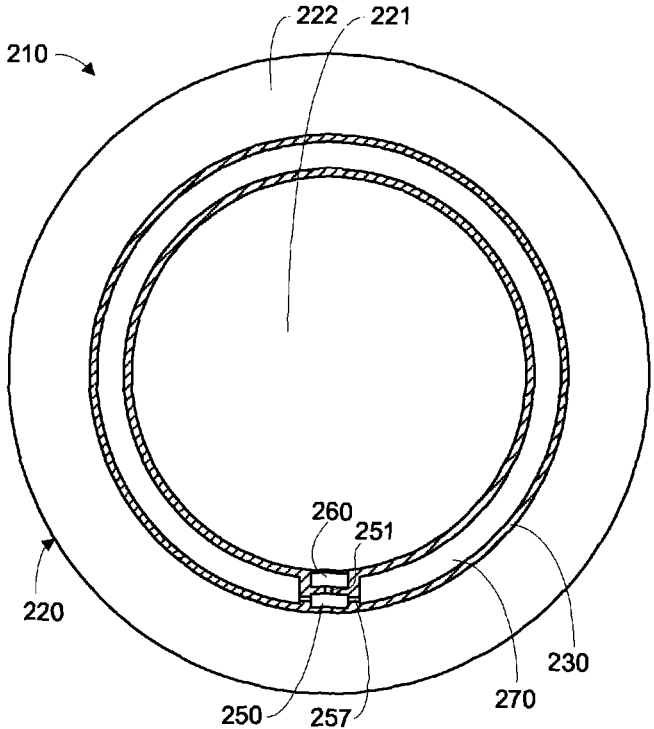


FIG. 2a

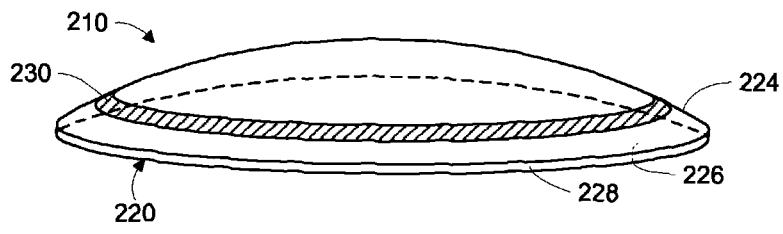


FIG. 2b

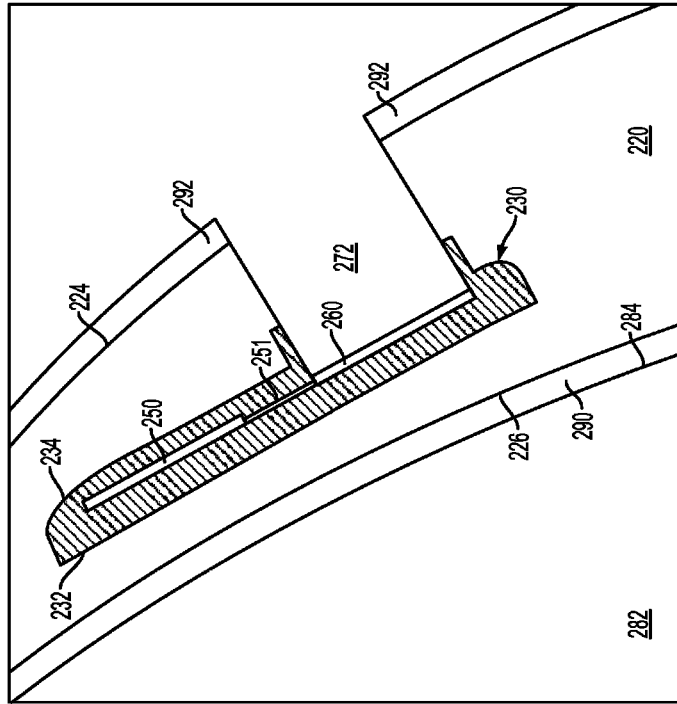


FIG. 2d

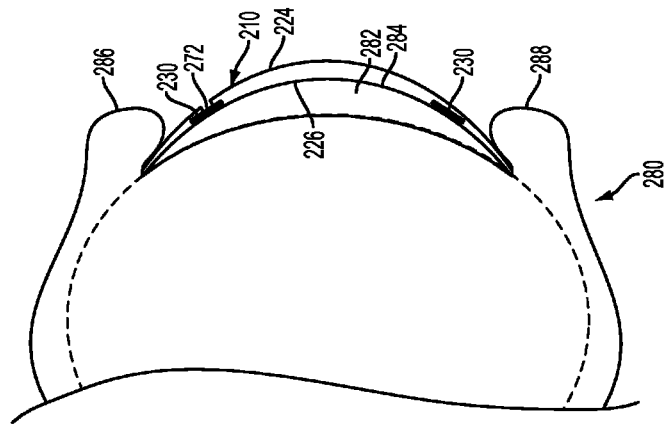


FIG. 2c

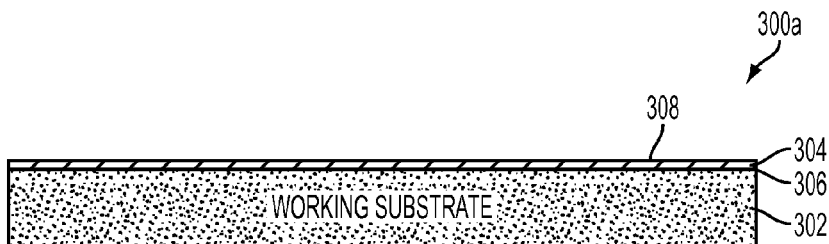


FIG. 3a

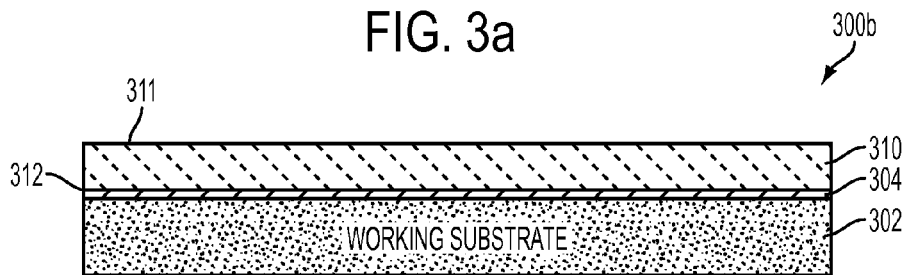


FIG. 3b

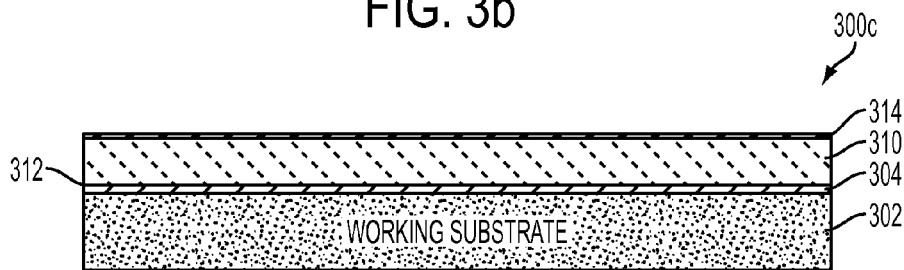


FIG. 3c

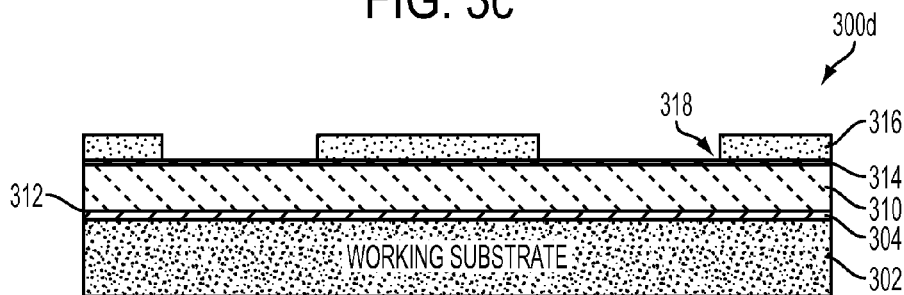


FIG. 3d

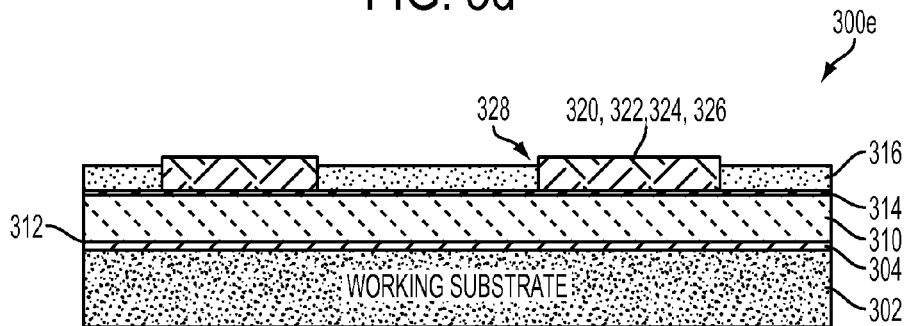


FIG. 3e



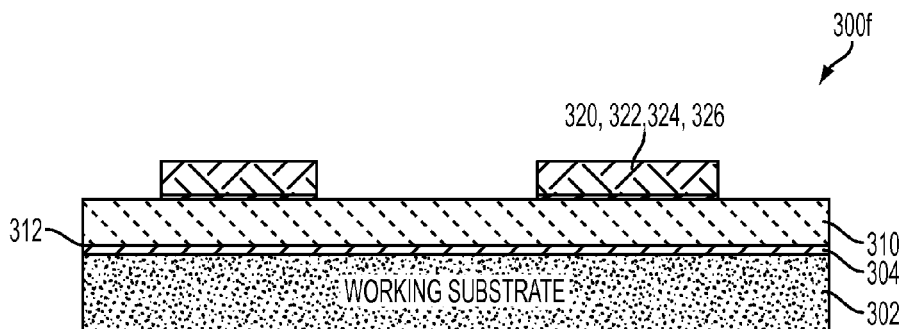


FIG. 3f

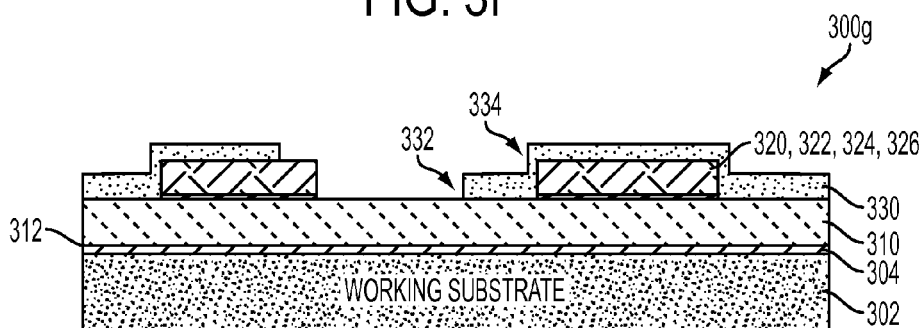


FIG. 3g

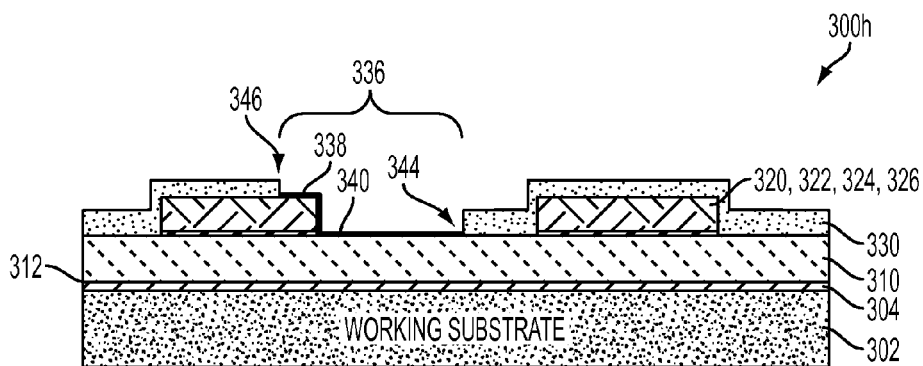


FIG. 3h

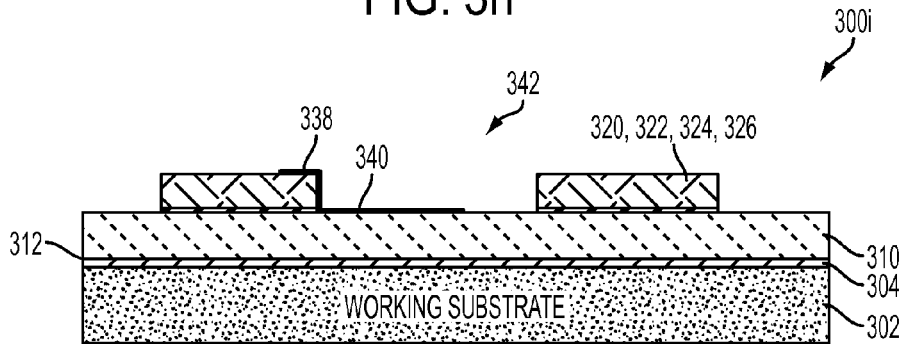


FIG. 3i

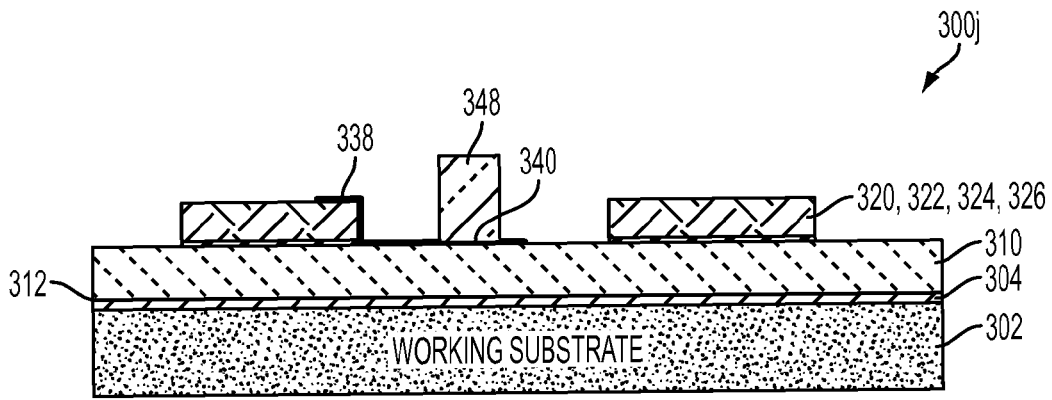


FIG. 3j

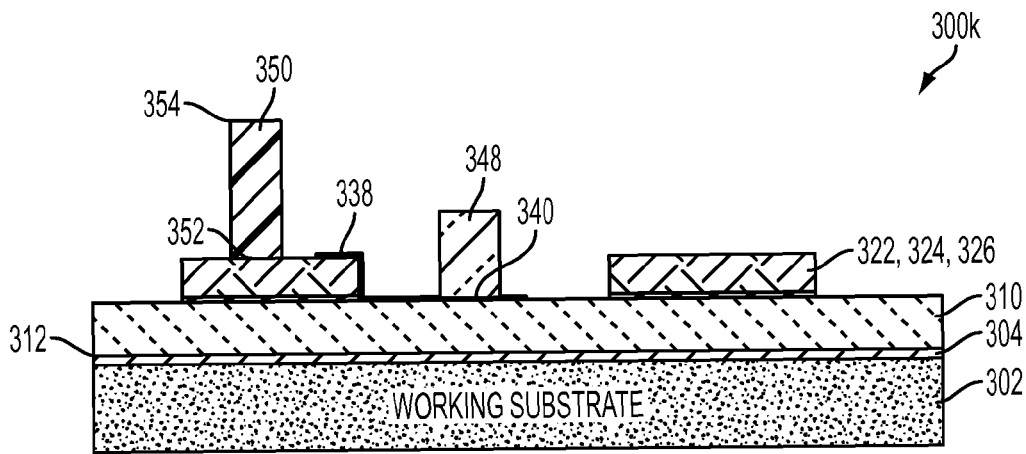


FIG. 3k

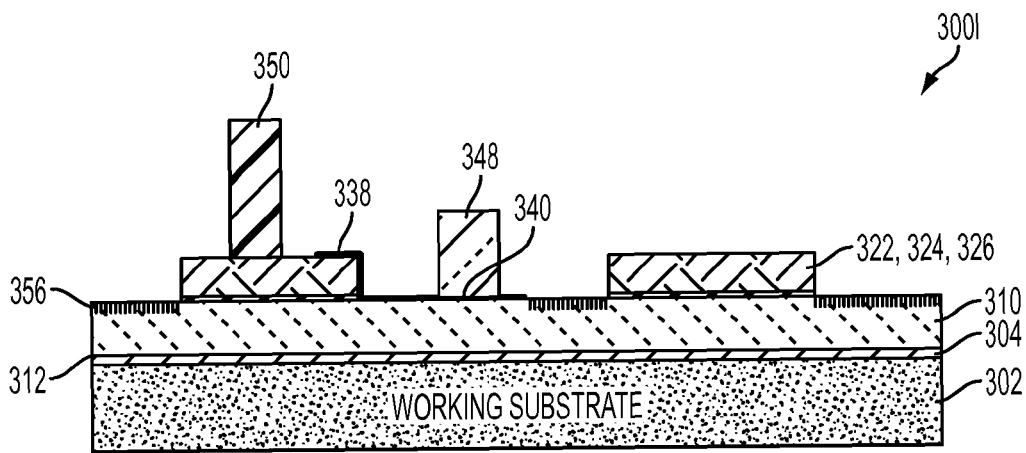


FIG. 3l

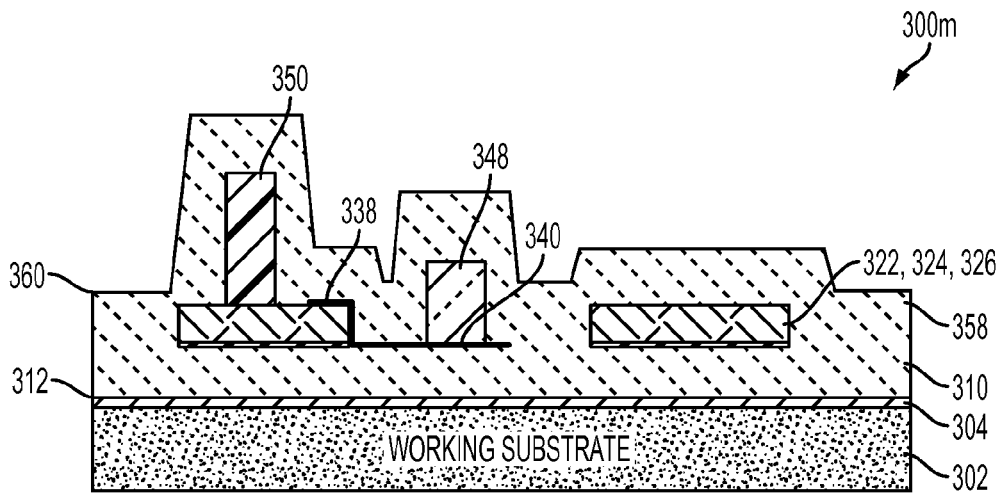


FIG. 3m

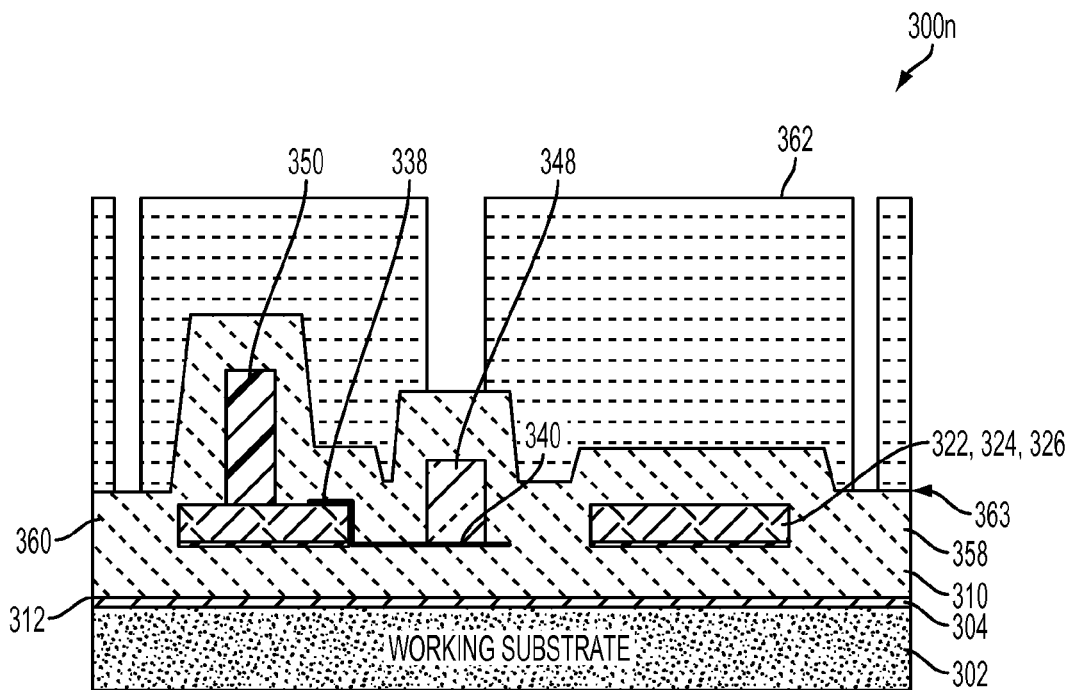


FIG. 3n

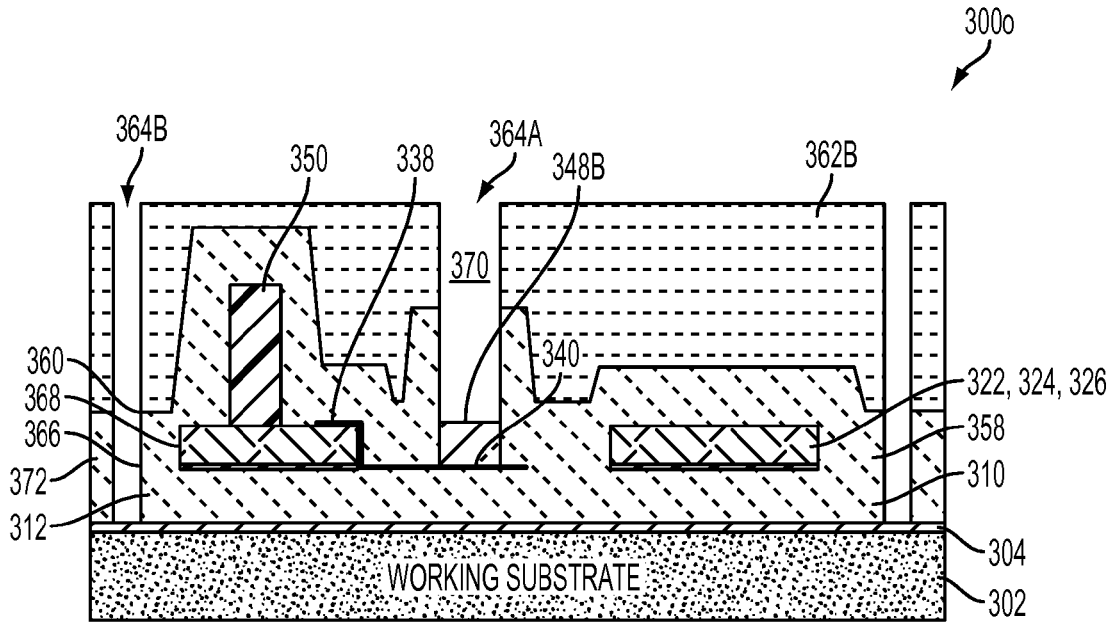


FIG. 3o

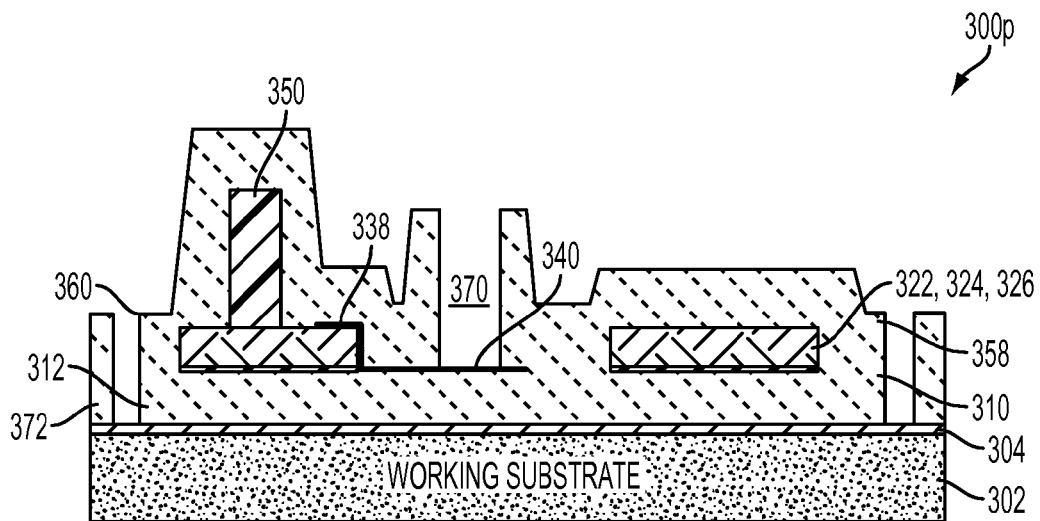


FIG. 3p

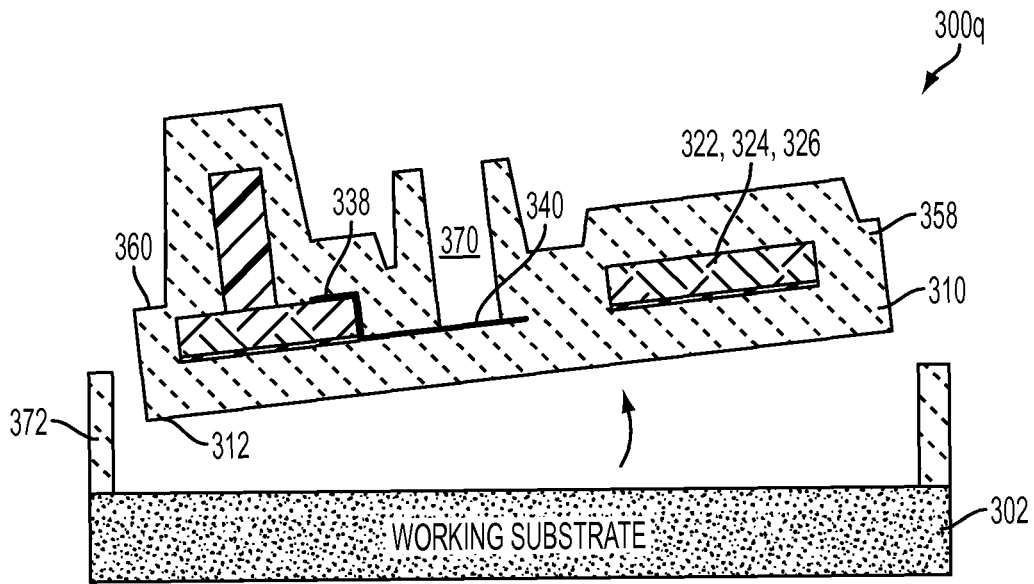


FIG. 3q

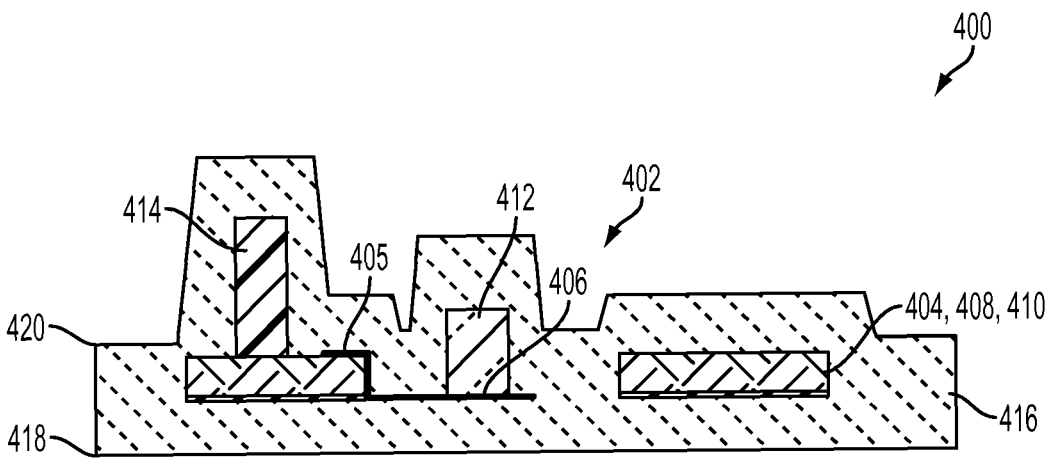


FIG. 4

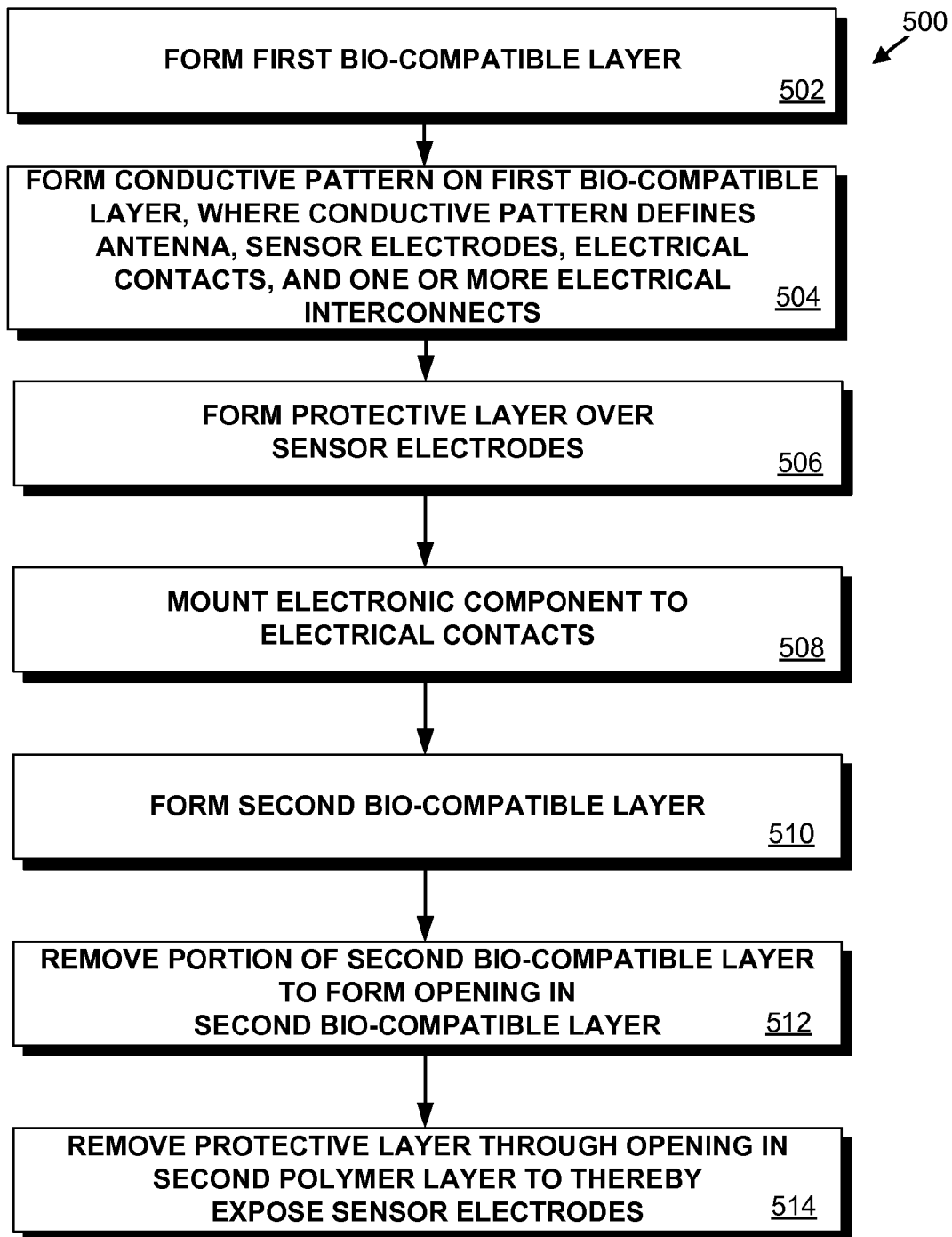
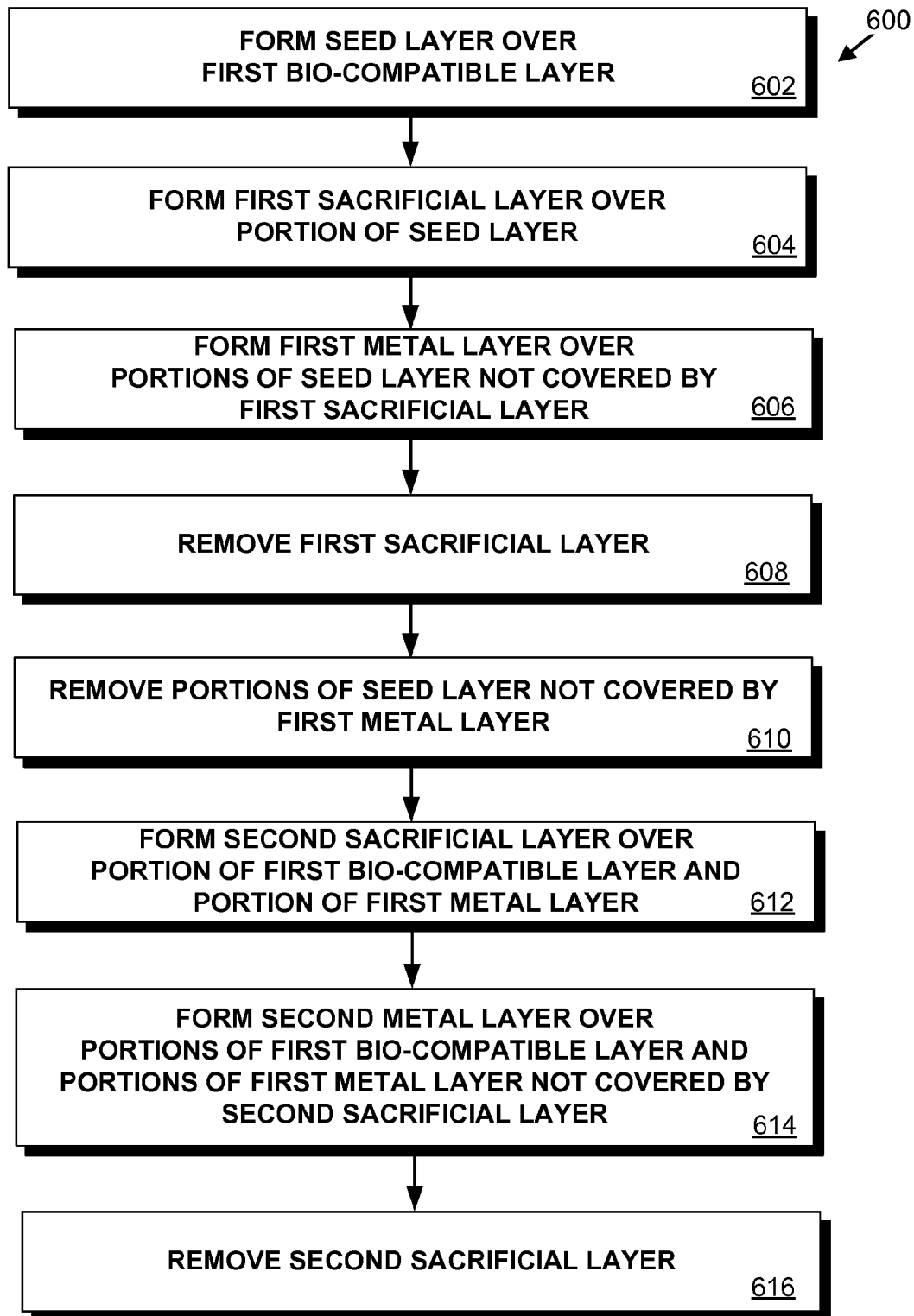
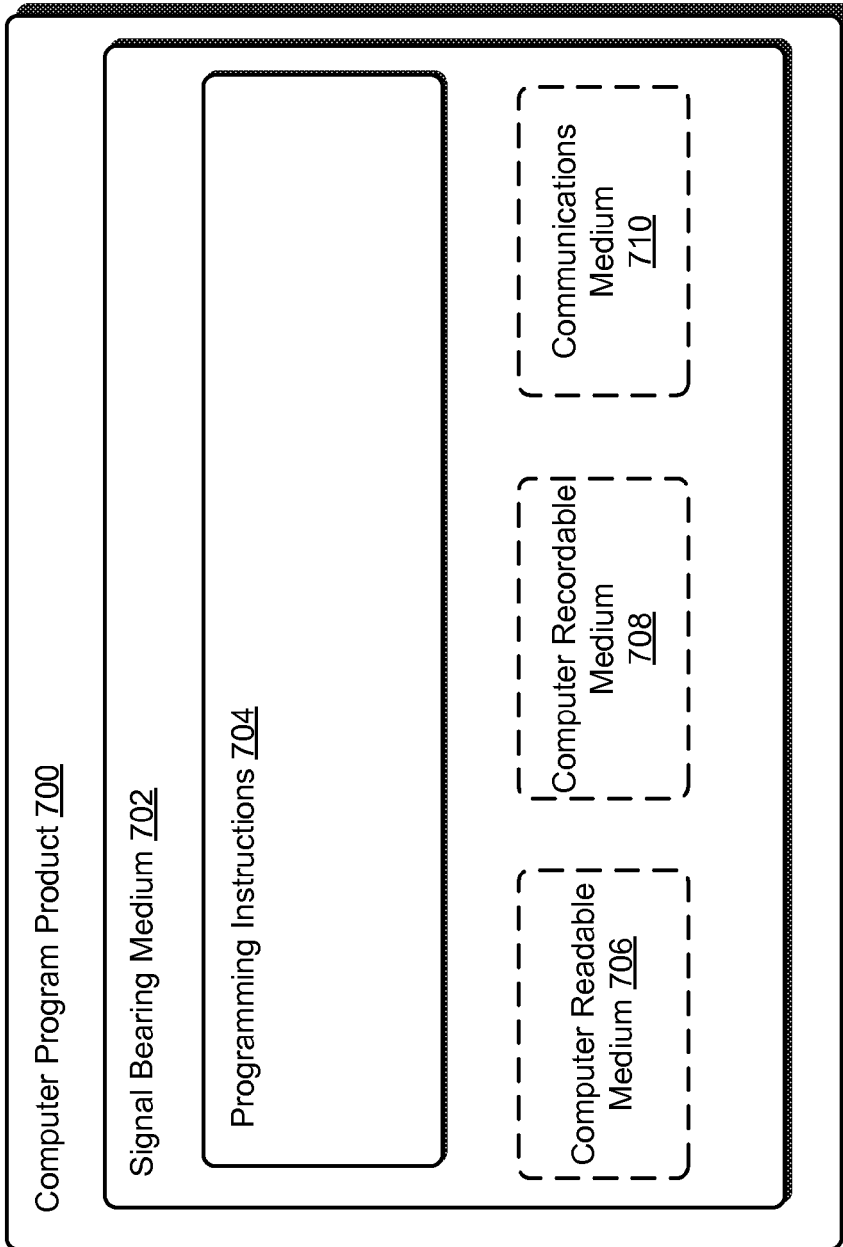


FIG. 5



**FIG. 6**



**FIG. 7**



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## FABRICATION METHODS FOR BIO-COMPATIBLE DEVICES

### BACKGROUND

Unless otherwise indicated herein, the materials described in this section are not prior art to the claims in this application and are not admitted to be prior art by inclusion in this section.

A body-mountable device may be configured to monitor health-related information based on at least one analyte from a user. For example, a bio-compatible device may be embedded in a polymer to provide the body-mountable device. The bio-compatible device includes a sensor configured to detect the at least one analyte (e.g., glucose) in a fluid of a user wearing the body-mountable device. The body-mountable device may also be configured to monitor various other types of health-related information.

### SUMMARY

In one aspect, a method involves: forming a first bio-compatible layer, wherein the first bio-compatible layer defines a first side of a bio-compatible device; forming a conductive pattern on the first bio-compatible layer, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects; forming a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer; mounting an electronic component to the electrical contacts; forming a second bio-compatible layer over the first bio-compatible layer, the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects, wherein the second bio-compatible layer defines a second side of the bio-compatible device; removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer; and removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes.

In another aspect, a device is disclosed. The device includes: a conductive pattern, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects; a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer; an electronic component mounted to the electrical contacts; and a bio-compatible layer over the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects, such that the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects are covered by the bio-compatible layer, wherein the bio-compatible layer defines a first side and a second side of a bio-compatible device.

In yet another aspect, a system is disclosed. The system includes: means for forming a first bio-compatible layer, wherein the first bio-compatible layer defines a first side of a bio-compatible device; means for forming a conductive pattern on the first bio-compatible layer, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects; means for forming a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer; means for mounting an electronic component to the electrical contacts; means for forming a second bio-compatible layer over the first bio-compatible layer, the electronic component, the antenna, the protective layer, the

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electrical contacts, and the one or more electrical interconnects, wherein the second bio-compatible layer defines a second side of the bio-compatible device; means for removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer; and means for removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes.

These as well as other aspects, advantages, and alternatives, will become apparent to those of ordinary skill in the art by reading the following detailed description, with reference where appropriate to the accompanying drawings.

### BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a block diagram of a system with an eye-mountable device in wireless communication with an external reader, according to an example embodiment.

FIG. 2a is a top view of an eye-mountable device, according to an example embodiment.

FIG. 2b is a side view of an eye-mountable device, according to an example embodiment.

FIG. 2c is a side cross-section view of the eye-mountable device of FIG. 2a while mounted to a corneal surface of the eye, according to an example embodiment.

FIG. 2d is a side cross-section view showing the tear film layers surrounding the surfaces of the eye-mountable device mounted as shown in FIG. 2c, according to an example embodiment.

FIG. 3a-g show stages of fabricating a bio-compatible device, according to an example embodiment.

FIG. 4 is an illustration of a device, according to an example embodiment.

FIG. 5 is a flow chart illustrating a method for fabricating a bio-compatible device, according to an example embodiment.

FIG. 6 is a flow chart illustrating a method for forming a conductive pattern, according to an example embodiment.

FIG. 7 depicts a computer-readable medium configured according to an example embodiment.

### DETAILED DESCRIPTION

The following detailed description describes various features and functions of the disclosed methods and systems with reference to the accompanying figures. In the figures, similar symbols typically identify similar components, unless context dictates otherwise. The illustrative method and system embodiments described herein are not meant to be limiting. It will be readily understood that certain aspects of the disclosed methods and systems can be arranged and combined in a wide variety of different configurations, all of which are contemplated herein.

### I. INTRODUCTION

Disclosed herein are bio-compatible devices and methods for fabricating a bio-compatible device. Once fabricated, the bio-compatible device could be surrounded by a polymer to provide a body-mountable device. Beneficially, the bio-compatible devices and methods for fabricating a bio-compatible device disclosed herein can be used in scenarios when the body-mountable device comprises a variety of mountable devices that are mounted on or in portions of the human body, such as an eye-mountable device, a tooth-mountable device, and/or a skin-mountable device.

## II. EXAMPLE SYSTEMS AND DEVICES

An example body-mountable device that comprises an eye-mountable device that is configured to detect at least one analyte in a tear film of a user wearing the eye-mountable device will now be described in greater detail.

FIG. 1 is a block diagram of a system 100 that includes an eye-mountable device 110 in wireless communication with an external reader 120. The eye-mountable device 110 may be a polymeric material that may be appropriately shaped for mounting to a corneal surface and in which a structure is at least partially embedded. The structure may include a power supply 140, a controller 150, bio-interactive electronics 160, and an antenna 170.

In some embodiments, the structure may be a bio-compatible device in which some or all of the components formed or mounted thereon are encapsulated by a bio-compatible material.

In some example embodiments, the structure may be positioned away from the center of the eye-mountable device 110 and thereby avoid interference with light transmission to the central, light-sensitive region of the eye. For example, where the eye-mountable device 110 is shaped as a curved disk, the structure may be embedded around the periphery (e.g., near the outer circumference) of the disk. In other example embodiments, the structure may be positioned in or near the central region of the eye-mountable device 110. For example, portions of the structure may be substantially transparent to incoming visible light to mitigate interference with light transmission to the eye. Moreover, in some embodiments, the bio-interactive electronics 160 may include a pixel array 164 that emits and/or transmits light to be received by the eye according to display instructions. Thus, the bio-interactive electronics 160 may optionally be positioned in the center of the eye-mountable device so as to generate visual cues perceivable to a wearer of the eye-mountable device 110, such as displaying information (e.g., characters, symbols, flashing patterns, etc.) on the pixel array 164.

The power supply 140 is configured to harvest ambient energy to power the controller 150 and bio-interactive electronics 160, and may include an energy harvesting antenna 142 and/or solar cells 144. The energy harvesting antenna 142 may capture energy from incident radio radiation. The solar cells 144 may comprise photovoltaic cells configured to capture energy from incoming ultraviolet, visible, and/or infrared radiation.

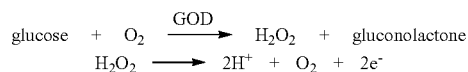
A rectifier/regulator 146 may be used to condition the captured energy to a stable DC supply voltage 141 at a level suitable for operating the controller, and then supply the voltage to the controller 150. The rectifier/regulator 146 may include one or more energy storage devices to mitigate high frequency variations in the energy harvesting antenna 142 and/or solar cell(s) 144. For example, one or more energy storage devices (e.g., a capacitor or an inductor) may be connected in parallel across the outputs of the rectifier/regulator 146 to regulate the DC supply voltage 141 and may be configured to function as a low-pass filter.

The controller 150 is configured to execute instructions to operate the bio-interactive electronics 160 and the antenna 170. The controller 150 includes logic circuitry configured to operate the bio-interactive electronics 160 so as to interact with a biological environment of the eye-mountable device 110. The interaction could involve the use of one or more components, such as an analyte bio-sensor 162 in the bio-interactive electronics 160, to obtain input from the biological environment. Additionally or alternatively, the interac-

tion could involve the use of one or more components, such as a pixel array 164, to provide an output to the biological environment.

In one example, the controller 150 includes a sensor interface module 152 that is configured to operate the analyte bio-sensor 162. The analyte bio-sensor 162 may be, for example, an amperometric electrochemical sensor that includes a working electrode and a reference electrode driven by a sensor interface. A voltage is applied between the working and reference electrodes to cause an analyte to undergo an electrochemical reaction (e.g., a reduction and/or oxidation reaction) at the working electrode. The electrochemical reaction generates an amperometric current that can be measured through the working electrode. The amperometric current can be dependent on the analyte concentration. Thus, the amount of the amperometric current that is measured through the working electrode can provide an indication of analyte concentration. In some embodiments, the sensor interface module 152 can be a potentiostat configured to apply a voltage difference between working and reference electrodes while measuring a current through the working electrode.

In some instances, a reagent may also be included to sensitize the electrochemical sensor to one or more desired analytes. For example, a layer of glucose oxidase ("GOD") proximal to the working electrode can catalyze glucose oxidation to generate hydrogen peroxide (H<sub>2</sub>O<sub>2</sub>). The hydrogen peroxide can then be electro-oxidized at the working electrode, which releases electrons to the working electrode, resulting in an amperometric current that can be measured through the working electrode.



The current generated by either reduction or oxidation reactions is approximately proportionate to the reaction rate. Further, the reaction rate is dependent on the rate of analyte molecules reaching the electrochemical sensor electrodes to fuel the reduction or oxidation reactions, either directly or catalytically through a reagent. In a steady state, where analyte molecules diffuse to the electrochemical sensor electrodes from a sampled region at approximately the same rate that additional analyte molecules diffuse to the sampled region from surrounding regions, the reaction rate is approximately proportionate to the concentration of the analyte molecules. The current measured through the working electrode thus provides an indication of the analyte concentration.

The controller 150 may also include a display driver module 154 for operating a pixel array 164. The pixel array 164 is an array of separately programmable light transmitting, light reflecting, and/or light emitting pixels arranged in rows and columns. The individual pixel circuits can optionally include liquid crystal technologies, microelectromechanical technologies, emissive diode technologies, etc. to selectively transmit, reflect, and/or emit light according to information from the display driver module 154. Such a pixel array 164 may also include more than one color of pixels (e.g., red, green, and blue pixels) to render visual content in color. The display driver module 154 can include, for example, one or more data lines providing programming information to the separately programmed pixels in the pixel array 164 and one or more addressing lines for setting

groups of pixels to receive such programming information. Such a pixel array **164** situated on the eye can also include one or more lenses to direct light from the pixel array to a focal plane perceivable by the eye.

The controller **150** may also include a communication circuit **156** for sending and/or receiving information via the antenna **170**. The communication circuit **156** may include one or more oscillators, mixers, frequency injectors, or the like to modulate and/or demodulate information on a carrier frequency to be transmitted and/or received by the antenna **170**. In some example embodiments, the eye-mountable device **110** is configured to indicate an output from a bio-sensor by modulating an impedance of the antenna **170** in a manner that is perceivable by the external reader **120**. For example, the communication circuit **156** can cause variations in the amplitude, phase, and/or frequency of backscatter radiation from the antenna **170**, and such variations may then be detected by the reader **120**.

The controller **150** is connected to the bio-interactive electronics **160** via interconnects **151**. Similarly, the controller **150** is connected to the antenna **170** via interconnects **157**. The interconnects **151**, **157** may comprise a patterned conductive material (e.g., gold, platinum, palladium, titanium, copper, aluminum, silver, metals, any combinations of these, etc.).

It is noted that the block diagram shown in FIG. **1** is described in connection with functional modules for convenience in description. However, embodiments of the eye-mountable device **110** can be arranged with one or more of the functional modules (“sub-systems”) implemented in a single chip, integrated circuit, and/or physical component.

Additionally or alternatively, the energy harvesting antenna **142** and the antenna **170** can be implemented in the same, dual-purpose antenna. For example, a loop antenna can both harvest incident radiation for power generation and communicate information via backscatter radiation.

The external reader **120** includes an antenna **128** (or group of more than one antennae) to send and receive wireless signals **171** to and from the eye-mountable device **110**. The external reader **120** also includes a computing system with a processor **126** in communication with a memory **122**. The memory **122** is a non-transitory computer-readable medium that can include, without limitation, magnetic disks, optical disks, organic memory, and/or any other volatile (e.g., RAM) or non-volatile (e.g., ROM) storage system readable by the processor **126**. The memory **122** includes a data storage **123** to store indications of data, such as sensor readings (e.g., from the analyte bio-sensor **162**), program settings (e.g., to adjust behavior of the eye-mountable device **110** and/or external reader **120**), etc. The memory **122** also includes program instructions **124** for execution by the processor **126**. For example, the program instructions **124** may cause the external reader **120** to provide a user interface that allows for retrieving information communicated from the eye-mountable device **110** (e.g., sensor outputs from the analyte bio-sensor **162**). The external reader **120** may also include one or more hardware components for operating the antenna **128** to send and receive the wireless signals **171** to and from the eye-mountable device **110**. For example, oscillators, frequency injectors, encoders, decoders, amplifiers, and filters can drive the antenna **128** according to instructions from the processor **126**.

The external reader **120** may be a smart phone, digital assistant, or other portable computing device with wireless connectivity sufficient to provide the wireless communication link **171**. The external reader **120** may also be implemented as an antenna module that can be plugged in to a

portable computing device, such as in an example where the communication link **171** operates at carrier frequencies not commonly employed in portable computing devices. In some instances, the external reader **120** is a special-purpose device configured to be worn relatively near a wearer’s eye to allow the wireless communication link **171** to operate using little or low power. For example, the external reader **120** can be integrated in a piece of jewelry such as a necklace, earring, etc. or integrated in an article of clothing worn near the head, such as a hat, headband, etc.

In an example where the eye-mountable device **110** includes an analyte bio-sensor **162**, the system **100** can be operated to monitor the analyte concentration in tear film on the surface of the eye. To perform a reading with the system **100** configured as a tear film analyte monitor, the external reader **120** can emit radio frequency radiation **171** that is harvested to power the eye-mountable device **110** via the power supply **140**. Radio frequency electrical signals captured by the energy harvesting antenna **142** (and/or the antenna **170**) are rectified and/or regulated in the rectifier/regulator **146** and a regulated DC supply voltage **141** is provided to the controller **150**. The radio frequency radiation **171** thus turns on the electronic components within the eye-mountable device **110**. Once turned on, the controller **150** operates the analyte bio-sensor **162** to measure an analyte concentration level. For example, the sensor interface module **152** can apply a voltage between a working electrode and a reference electrode in the analyte bio-sensor **162**. The applied voltage can be sufficient to cause the analyte to undergo an electrochemical reaction at the working electrode and thereby generate an amperometric current that can be measured through the working electrode. The measured amperometric current can provide the sensor reading (“result”) indicative of the analyte concentration. The controller **150** can operate the antenna **170** to communicate the sensor reading back to the external reader **120** (e.g., via the communication circuit **156**).

In some embodiments, the system **100** can operate to non-continuously (“intermittently”) supply energy to the eye-mountable device **110** to power the controller **150** and electronics **160**. For example, radio frequency radiation **171** can be supplied to power the eye-mountable device **110** long enough to carry out a tear film analyte concentration measurement and communicate the results. For example, the supplied radio frequency radiation can provide sufficient power to apply a potential between a working electrode and a reference electrode sufficient to induce electrochemical reactions at the working electrode, measure the resulting amperometric current, and modulate the antenna impedance to adjust the backscatter radiation in a manner indicative of the measured amperometric current. In such an example, the supplied radio frequency radiation **171** can be considered an interrogation signal from the external reader **120** to the eye-mountable device **110** to request a measurement. By periodically interrogating the eye-mountable device **110** (e.g., by supplying radio frequency radiation **171** to temporarily turn the device on) and storing the sensor results (e.g., via the data storage **123**), the external reader **120** can accumulate a set of analyte concentration measurements over time without continuously powering the eye-mountable device **110**.

FIG. **2a** is a top view of an eye-mountable device **210**. FIG. **2b** is side view of the eye-mountable device **210**. It is noted that relative dimensions in FIGS. **2a** and **2b** are not necessarily to scale, but have been rendered for purposes of explanation only in describing the arrangement of the eye-mountable device **210**.

The eye-mountable device **210** may include a polymeric material **220**, which may be a substantially transparent material to allow incident light to be transmitted to the eye. The polymeric material **220** may include one or more bio-compatible materials similar to those employed to form vision correction and/or cosmetic contact lenses in optometry, such as polyethylene terephthalate (“PET”), polymethyl methacrylate (“PMMA”), polyhydroxyethylmethacrylate (“polyHEMA”), silicone hydrogels, or any combinations of these. Other polymeric materials may also be envisioned. The polymeric material **220** may include materials configured to moisturize the corneal surface, such as hydrogels and the like. In some embodiments, the polymeric material **220** is a deformable (“non-rigid”) material to enhance wearer comfort.

To facilitate contact-mounting, the eye-mountable device **210** may comprise a concave surface **226** configured to adhere (“mount”) to a moistened corneal surface (e.g., by capillary forces with a tear film coating the corneal surface). While mounted with the concave surface against the eye, a convex surface **224** of eye-mountable device **210** is formed so as not to interfere with eye-lid motion while the eye-mountable device **210** is mounted to the eye. A circular outer side edge **228** connects the concave surface **224** and the convex surface **226**. The convex surface **224** can therefore be considered an outer, top surface of the eye-mountable device **210** whereas the concave surface **226** can be considered an inner, bottom surface. The “top” view shown in FIG. **2a** is facing the convex surface **224**.

The eye-mountable device **210** can have dimensions similar to a vision correction and/or cosmetic contact lenses, such as a diameter of approximately 1 centimeter, and a thickness of about 0.1 to about 0.5 millimeters. However, the diameter and thickness values are provided for explanatory purposes only. In some embodiments, the dimensions of the eye-mountable device **210** may be selected according to the size and/or shape of the corneal surface and/or the scleral surface of the wearer’s eye. In some embodiments, the eye-mountable device **210** is shaped to provide a predetermined, vision-correcting optical power, such as provided by a prescription contact lens.

A structure **230** is embedded in the eye-mountable device **210**. The structure **230** can be embedded to be situated near or along an outer periphery **222**, away from a central region **221**. Such a position ensures that the structure **230** will not interfere with a wearer’s vision when the eye-mountable device **210** is mounted on a wearer’s eye, because it is positioned away from the central region **221** where incident light is transmitted to the light-sensing portions of the eye. Moreover, portions of the structure **230** can be formed of a transparent material to further mitigate effects on visual perception.

The structure **230** may be shaped as a flat, circular ring (e.g., a disk with a centered hole). The flat surface of the structure **230** (e.g., along the radial width) allows for mounting electronics such as chips (e.g., via flip-chip mounting) and for patterning conductive materials to form electrodes, antenna(e), and/or interconnections. The structure **230** and the polymeric material **220** may be approximately cylindrically symmetric about a common central axis. The structure **230** may have, for example, a diameter of about 10 millimeters, a radial width of about 1 millimeter (e.g., an outer radius 1 millimeter greater than an inner radius), and a thickness of about 50 micrometers. These dimensions are provided for example purposes only, and in no way limit this disclosure.

A loop antenna **270**, controller **250**, and bio-interactive electronics **260** are included in the structure **230**. The controller **250** may be a chip including logic elements configured to operate the bio-interactive electronics **260** and the loop antenna **270**. The controller **250** is electrically connected to the loop antenna **270** by interconnects **257** also situated on the structure **230**. Similarly, the controller **250** is electrically connected to the bio-interactive electronics **260** by an interconnect **251**. The interconnects **251**, **257**, the loop antenna **270**, and any conductive electrodes (e.g., for an electrochemical analyte bio-sensor, etc.) may be formed from any type of conductive material and may be patterned by any process that can be used for patterning such materials, such as deposition or photolithography, for example. The conductive materials patterned on the structure **230** may be, for example, gold, platinum, palladium, titanium, carbon, aluminum, copper, silver, silver-chloride, conductors formed from noble materials, metals, or any combinations of these materials. Other materials may also be envisioned.

The structure **230** may be a bio-compatible device in which some or all of the components are encapsulated by a bio-compatible material. In one example, the controller **250**, interconnects **251**, **257**, bio-interactive electronics **260**, and the loop antenna **270** are fully encapsulated by bio-compatible material, except for the sensor electrodes in the bio-interactive electronics **260**.

As shown in FIG. **2a**, the bio-interactive electronics module **260** is on a side of the structure **230** facing the convex surface **224**. Where the bio-interactive electronics module **260** includes an analyte bio-sensor, for example, mounting such a bio-sensor on the structure **230** to be close to the convex surface **224** allows the bio-sensor to sense analyte that has diffused through convex surface **224** or has reached the bio-sensor through a channel in the convex surface **224** (FIGS. **2c** and **2d** show a channel **272**).

The loop antenna **270** is a layer of conductive material patterned along the flat surface of the structure **230** to form a flat conductive ring. In some example embodiments, the loop antenna **270** does not form a complete loop. For example, the loop antenna **270** may include a cutout to allow room for the controller **250** and bio-interactive electronics **260**, as illustrated in FIG. **2a**. However, in another example embodiment, the loop antenna **270** can be arranged as a continuous strip of conductive material that wraps entirely around the structure **230** one or more times. Interconnects between the ends of such a wound antenna (e.g., the antenna leads) can connect to the controller **250** in the structure **230**. In some embodiments, the loop antenna can include a plurality of conductive loops spaced apart from each other, such as three conductive loops, five conductive loops, nine conductive loops, etc. With such an arrangement, the polymeric material **220** may extend between adjacent conductive loops in the plurality of conductive loops.

FIG. **2c** is a side cross-section view of the eye-mountable electronic device **210** mounted to a corneal surface **284** of an eye **280**. FIG. **2d** is an enlarged partial view of the cross-section of the eye-mountable device shown in FIG. **2c**. It is noted that relative dimensions in FIGS. **2c** and **2d** are not necessarily to scale, but have been rendered for purposes of explanation only in describing the arrangement of the eye-mountable device **210**. Some aspects are exaggerated to allow for illustration and to facilitate explanation.

The eye **280** includes a cornea **282** that is covered by bringing an upper eyelid **286** and a lower eyelid **288** together over the surface of the eye **280**. Incident light is received by the eye **280** through the cornea **282**, where light is optically directed to light sensing elements of the eye **280** to stimulate

visual perception. The motion of the upper and lower eyelids **286, 288** distributes a tear film across the exposed corneal surface **284** of the eye **280**. The tear film is an aqueous solution secreted by the lacrimal gland to protect and lubricate the eye **280**. When the eye-mountable device **210** is mounted in the eye **280**, the tear film coats both the concave and convex surfaces **224, 226**, providing an inner layer **290** (along the concave surface **226**) and an outer layer **292** (along the convex surface **224**). The inner layer **290** on the corneal surface **284** also facilitates mounting the eye-mountable device **210** by capillary forces between the concave surface **226** and the corneal surface **284**. In some embodiments, the eye-mountable device **210** can also be held over the eye **280** in part by vacuum forces against the corneal surface **284** due to the curvature of the concave surface **226**. The tear film layers **290, 292** may be about 10 micrometers in thickness and together account for about 10 microliters of fluid.

The tear film is in contact with the blood supply through capillaries in the structure of the eye and includes many biomarkers found in blood that are analyzed to diagnose health states of an individual. For example, tear film includes glucose, calcium, sodium, cholesterol, potassium, other biomarkers, etc. The biomarker concentrations in tear film can be systematically different than the corresponding concentrations of the biomarkers in the blood, but a relationship between the two concentration levels can be established to map tear film biomarker concentration values to blood concentration levels. For example, the tear film concentration of glucose can be established (e.g., empirically determined) to be approximately one tenth the corresponding blood glucose concentration. Although another ratio relationship and/or a non-ratio relationship may be used. Thus, measuring tear film analyte concentration levels provides a non-invasive technique for monitoring biomarker levels in comparison to blood sampling techniques performed by lancing a volume of blood to be analyzed outside a person's body.

As shown in the cross-sectional views in FIGS. **2c** and **2d**, the structure **230** can be inclined so as to be approximately parallel to the adjacent portion of the convex surface **224**. As described above, the structure **230** is a flattened ring with an inward-facing surface **232** (closer to the concave surface **226** of the polymeric material **220**) and an outward-facing surface **234** (closer to the convex surface **224**). The structure **230** can include electronic components and/or patterned conductive materials adjacent to either or both surfaces **232, 234**.

As shown in FIG. **2d**, the bio-interactive electronics **260**, the controller **250**, and the conductive interconnect **251** are located between the outward-facing surface **234** and the inward-facing surface **232** such that the bio-interactive electronics **260** are facing the convex surface **224**. With this arrangement, the bio-interactive electronics **260** can receive analyte concentrations in the tear film **292** through the channel **272**. However, in other examples, the bio-interactive electronics **260** may be mounted on the inward-facing surface **232** of the structure **230** such that the bio-interactive electronics **260** are facing the concave surface **226**.

While the body-mountable device has been described as comprising the eye-mountable device **110** and/or the eye-mountable device **210**, the body-mountable device could comprise other mountable devices that are mounted on or in other portions of the human body.

For example, in some embodiments, the body-mountable device may comprise a tooth-mountable device. In some embodiments, the tooth-mountable device may take the

form of or be similar in form to the eye-mountable device **110** and/or the eye-mountable device **210**. For instance, the tooth-mountable device could include a polymeric material that is the same or similar to any of the polymeric materials described herein and a structure that is the same or similar to any of the structures described herein. With such an arrangement, the tooth-mountable device may be configured to detect at least one analyte in a fluid (e.g., saliva) of a user wearing the tooth-mountable device.

Moreover, in some embodiments, the body-mountable device may comprise a skin-mountable device. In some embodiments, the skin-mountable device may take the form of or be similar in form to the eye-mountable device **110** and/or the eye-mountable device **210**. For instance, the skin-mountable device could include a polymeric material that is the same or similar to any of the polymeric materials described herein and a structure that is the same or similar to any of the structures described herein. With such an arrangement, the skin-mountable device may be configured to detect at least one analyte in a fluid (e.g., perspiration, blood, etc.) of a user wearing the skin-mountable device.

Further, some embodiments may include privacy controls which may be automatically implemented or controlled by the wearer of a body-mountable device. For example, where a wearer's collected physiological parameter data and health state data are uploaded to a cloud computing network for trend analysis by a clinician, the data may be treated in one or more ways before it is stored or used, so that personally identifiable information is removed. For example, a user's identity may be treated so that no personally identifiable information can be determined for the user, or a user's geographic location may be generalized where location information is obtained (such as to a city, ZIP code, or state level), so that a particular location of a user cannot be determined.

Additionally or alternatively, wearers of a body-mountable device may be provided with an opportunity to control whether or how the device collects information about the wearer (e.g., information about a user's medical history, social actions or activities, profession, a user's preferences, or a user's current location), or to control how such information may be used. Thus, the wearer may have control over how information is collected about him or her and used by a clinician or physician or other user of the data. For example, a wearer may elect that data, such as health state and physiological parameters, collected from his or her device may only be used for generating an individual baseline and recommendations in response to collection and comparison of his or her own data and may not be used in generating a population baseline or for use in population correlation studies.

### III. EXAMPLE METHODS

FIGS. **3a-q** illustrate stages in a process for fabricating a bio-compatible device, such as a bio-compatible device **300q** shown in FIG. **3q**. The illustrations shown in FIGS. **3a-q** are generally shown in cross-sectional views to illustrate sequentially formed layers developed to create the bio-compatible device. The layers can be developed by microfabrication and/or manufacturing techniques such as, for example, electroplating, photolithography, deposition, and/or evaporation fabrication processes and the like. The various materials may be formed according to patterns using photoresists and/or masks to pattern materials in particular arrangements, such as to form wires, electrodes, electrical contacts, etc. Additionally, electroplating techniques may

also be employed to coat an arrangement of electrodes with a metallic plating. For example, an arrangement of conductive material formed by a deposition and/or photolithography process can be plated with a metallic material to create a conductive structure with a desired thickness. However, the dimensions, including relative thicknesses, of the various layers illustrated and described in connection with FIGS. 3a-g to create a bio-compatible device are not illustrated to scale. Instead, the drawings in FIGS. 3a-g schematically illustrate the ordering of the various layers for purposes of explanation only.

FIG. 3a illustrates a working substrate 302 with a sacrificial metal layer 304 formed on the working substrate 302 to provide a partially-fabricated device 300a. The working substrate 302 may be any flat surface on which the layers of the encapsulated electronics structure can be assembled. For example, the working substrate 302 may be a wafer (e.g., a silicon wafer) similar to those used in the fabrication of semiconductor devices and/or microelectronics.

In the illustrated example, the sacrificial metal layer 304 includes a first sacrificial metal layer 306 and a second sacrificial metal layer 308. However, in other examples, the sacrificial metal layer 304 may include one metal layer or more than two metal layers, such as three metal layers, four metal layers, five metal layers, etc.

The first sacrificial metal layer 306 and/or the second sacrificial metal layer 308 may include a variety of metals. For example, the first sacrificial metal layer 306 may include titanium, and the second sacrificial metal layer 308 may include aluminum. With this arrangement, the first sacrificial layer 306 may adhere to the working substrate 302, and the second sacrificial metal layer 308 may bond to a bio-compatible layer.

Moreover, the first sacrificial metal layer 306 and/or the second sacrificial metal layer 308 may have a variety of thicknesses. For example, the first sacrificial metal layer 306 may have a thickness between 15 to 30 nanometers, such as 30 nanometers. And the second sacrificial metal layer 308 may have a thickness between 100 to 400 nanometers, such as 200 nanometers. Other thicknesses for the first sacrificial metal layer 306 and/or the second sacrificial metal layer 308 are possible as well.

In an example, the sacrificial metal layer 304 may be formed on the working substrate 302 by a microfabrication process, such as evaporation. However, in other examples, the sacrificial metal layer 304 may be formed on the working substrate 302 by other microfabrication processes, such as sputtering. In some embodiments, the first sacrificial metal layer 306 may be formed over the working substrate 302, and the second sacrificial metal layer 308 may be formed over the first sacrificial metal layer 306.

Moreover, the working substrate 302 may be cleaned before forming the sacrificial metal layer 304. The working substrate 302 may be cleaned in a variety of ways. For example, the working substrate 302 may be cleaned by soaking in a first fluid, rinsing with a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include isopropyl alcohol (IPA). Further, in some embodiments, the gas may include nitrogen. All of the rinsing described herein may be performed in a variety of ways, such as soaking in a bath in a tank, an automated spray, manually via a squirt bottle, etc.

Further, the working substrate 302 may be baked before forming the sacrificial metal layer 304. The working substrate 302 may be baked in a variety of ways. For example, the working substrate 302 may be baked at a temperature for

a time period. In some embodiments, the temperature may be 90 degrees Celsius (C). Moreover, in some embodiments, the time period may be 2 minutes.

Further still, the working substrate 302 may be plasma cleaned before forming the sacrificial metal layer 304. The working substrate 302 may be plasma cleaned in a variety of ways. For example, the working substrate 302 may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 5 minutes.

As shown in FIG. 3b, a first bio-compatible layer 310 is formed on the sacrificial metal layer 304 to provide a partially-fabricated device 300b. The first bio-compatible layer 310 defines a first side 312 of a bio-compatible device. That is, the first bio-compatible layer 310 defines an outer edge of the bio-compatible device.

The first bio-compatible layer 310 may include a variety of materials. For example, the first bio-compatible layer 310 may include a polymeric material such as SCS parylene-C (e.g., dichlorodi-p-xylylene), a polyethylene terephthalate (PET), a polydimethylsiloxane (PDMS), other silicone elastomers, and/or another bio-compatible polymeric material. The term "bio-compatibility," as used in this disclosure, refers generally to the ability of a material or device to co-exist with a biological host. Bio-compatible materials are generally those that do not bring about a host response (such as an immune response) that results in deleterious effects to either the biological host or the material. In addition to being bio-compatible, the first bio-compatible layer 310 may be an electrically insulating material to isolate encapsulated electronics from the surrounding environment (e.g., from current-carrying particles and/or fluids).

Moreover, the first bio-compatible layer 310 may have a variety of thicknesses. For example, the first bio-compatible layer 310 may have a thickness between 5 to 50 micrometers, such as 15 micrometers. Other thicknesses of the first bio-compatible layer 310 are possible as well.

In an example, the first bio-compatible layer 310 may be formed by a microfabrication process such as chemical vapor deposition, and provides a surface on which various components can be formed. The first bio-compatible layer 310 may be deposited onto the sacrificial metal layer 304 with a substantially uniform thickness such that a surface of the first bio-compatible layer 310 opposite the working substrate 302 forms a flat surface. In addition, the first bio-compatible layer 310 may have sufficient structural rigidity to be used as a substrate for assembling various components. In some embodiments, the first bio-compatible layer 310 may be a conformal coat. And as noted above, the second sacrificial metal layer 308 might bond to a bio-compatible layer, such as the first bio-compatible layer 310.

In an example, equipment that forms the first bio-compatible layer 310 may be preheated for 1 hour before forming the first bio-compatible layer 310. Moreover, in an example, 35 grams of a polymeric material may be used to form the first bio-compatible layer 310.

Moreover, an adhesion promoter may be applied to the sacrificial metal layer 304 before the first bio-compatible layer 310 is formed. In some embodiments, the adhesion promoter may comprise 3-methacryloxypropyltrimethoxysilane. And in such embodiments, the adhesion promoter may be A174 sold by Specialty Coating Systems and/or Sigma Aldrich. Other adhesion promoters are possible as well.

The adhesion promoter may be applied in a variety of ways. For example, the adhesion promoter may be applied by spin coating at a rate, baking at a temperature for a first time period, rinsing with a fluid, and baking at the tempera-

ture for a second time period. In some embodiments, the rate may be 3000 rotations per minute (rpm). And in such embodiments, applying the adhesion promoter by spin coating may involve accelerating and/or decelerating the partially-fabricated device **300a** at a rate between 100 to 3000 rpm per second, such as 1000 to 1500 rpm per second. Moreover, in some embodiments, the temperature may be 90 degrees C. Further, in some embodiments, the first time period may be 2 minutes. Further still, in some embodiments, the fluid may include IPA. And, in some embodiments, the second time period may be 1 minute.

In another example, the adhesion promoter may be applied by soaking the partially-fabricated device **300a** in a mixture including the adhesion promoter for a first time period, air drying on a towel for a second time period, rinsing with one or more fluids, and drying with a gas. In some embodiments, the mixture may comprise 100 parts deionized water (DI water), 100 parts IPA, and 1 part the adhesion promoter. Moreover, in some embodiments, the mixture may settle for 2 hours before soaking the partially-fabricated device **300a** in the mixture. Further, in some embodiments, the first time period may be 30 minutes. Moreover, in some embodiments, the second time period may be 30 minutes. Further, in some embodiments, the one or more fluids may include IPA and DI water. And, in some embodiments, the gas may include nitrogen. In such an example, soaking the partially-fabricated device **300a** in a mixture including the adhesion promoter for the first time period, air drying on a towel for the second time period, rinsing with one or more fluids, and/or drying with the gas may occur at room temperature. Moreover, in such an example, applying the adhesion promoter may further involve baking the partially-fabricated device **300a** at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 2 minutes.

Moreover, the partially-fabricated device **300a** may be cleaned before applying the adhesion promoter to the sacrificial metal layer **304**. The partially-fabricated device **300a** may be cleaned in a variety of ways. For example, the partially-fabricated device **300a** may be cleaned by rinsing in a fluid, drying with a gas, and baking at a temperature for a time period. In some embodiments, the fluid may include IPA. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 2 minutes.

Further, the partially-fabricated device **300a** may be plasma cleaned before applying the adhesion promoter to the sacrificial metal layer **304**. The partially-fabricated device **300a** may be plasma cleaned in a variety of ways. For example, the partially-fabricated device **300a** may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 5 minutes.

Next, a seed layer **314** is formed over the first bio-compatible layer **310** to provide a partially-fabricated device **300c**, as shown in FIG. 3c. Such a seed layer **314** can be used to adhere to both the first bio-compatible layer **310**, and any additional metal structure that is patterned over the seed layer **314**, as will be described below. For example, the seed layer **314** may include one or more materials that both adheres well to the first bio-compatible layer **310** and serves as a guide to electroplate the remainder of a metal structure that forms a component. In such an example, the seed layer

**314** may include palladium and/or gold. In some embodiments, the seed layer **314** may include a palladium layer and a gold layer.

Moreover, the seed layer **314** may have a variety of thicknesses. For example, a palladium layer of the seed layer **314** may have a thickness between 20 to 30 nanometers, such as 30 nanometers. Moreover, a gold layer of the seed layer **314** may have a thickness of 100 nanometers. Other thicknesses of the seed layer **314** are possible as well.

In an example, the seed layer **314** may be formed by a microfabrication process such as evaporation. However, in other examples, the seed layer **314** may be formed by other microfabrication processes, such as sputtering. In some embodiments, a palladium layer of the seed layer **314** may be formed over the first bio-compatible layer **310**, and a gold layer of the seed layer **314** may be formed over the palladium layer of the seed layer **314**.

Moreover, the partially-fabricated device **300b** may be cleaned before forming the seed layer **314** over the first bio-compatible layer **310**. The partially-fabricated device **300b** may be cleaned in a variety of ways. For example, the partially-fabricated device **300b** may be cleaned by soaking in a first fluid, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include IPA. Further, in some embodiments, the gas may include nitrogen.

Further, the partially-fabricated device **300b** may be baked before forming the seed layer **314** over the first bio-compatible layer **310**. The partially-fabricated device **300b** may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 5 minutes. Further, in some embodiments, the partially-fabricated device **300b** may be baked on a hot plate. After the partially-fabricated device **300b** is baked, the partially-fabricated device **300b** may be cooled to room temperature.

Further still, the partially-fabricated device **300b** may be plasma cleaned before forming the seed layer **314** over the first bio-compatible layer **310**. With this arrangement, a surface **311** of the first bio-compatible layer **310** (as shown in FIG. 3b) may be roughened, such that adhesion of the seed layer **314** to the first bio-compatible layer **310** may be improved. The partially-fabricated device **300b** may be plasma cleaned in a variety of ways. For example, the partially-fabricated device **300b** may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 5 minutes.

In another example, the surface **311** of the first bio-compatible layer may be treated before forming the seed layer **314**. With this arrangement, the surface **311** of the first bio-compatible layer **310** may be roughened, such that adhesion of the seed layer **314** to the first bio-compatible layer **310** may be improved. The surface **311** may be treated in a variety of ways. For example, the surface **311** of the first bio-compatible layer **310** may be treated by etching using an inductively coupled plasma at a power for a time. In some embodiments, the inductively coupled plasma may include an oxygen plasma. Moreover, in some embodiments, the power may be 400 Watts (W) with a 300 W bias. Further, in some embodiments, the time period may be 1 to 3 minutes. Other plasmas and/or types of plasmas may be used as well, such as plasma asher, a reactive ion etcher, etc.

As shown in FIG. 3d, a first sacrificial layer **316** is formed over a portion **318** of the seed layer **314** to provide a partially-fabricated device **300d**. The first sacrificial layer

**316** may include a variety of materials. For example, the first sacrificial layer **316** may include a photoresist layer, such as a photoresist layer comprising 2-ethoxyethyl acetate. In such an example, the first sacrificial layer **316** may be AZ4620® sold by Capital Scientific.

Moreover, the first sacrificial layer **316** may have a variety of thicknesses. For example, the first sacrificial layer **316** may have thicknesses of 5 micrometers. Other thicknesses of the first sacrificial layer **316** are possible as well.

In an example, the first sacrificial layer **316** may be formed over the portion **318** of the first bio-compatible layer **310** by spin coating and patterning.

The first sacrificial layer **316** may be spin coated in a variety of ways. For example, a material may be spin coated by placing the material on the partially-fabricated device **300c**, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the material on the partially-fabricated device **300c** may include pouring (or pipetting) the material onto the partially-fabricated device **300c**.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300c** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 8 seconds. With this arrangement, the material may be spread over the seed layer **314**. The spread cycle may further include accelerating the partially-fabricated device **300c** at a second rate for a second time period before rotating the partially-fabricated device **300c** at the first rate for the first time period. In some embodiments, the second rate may be 250 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300c** at a first rate for a first time period. And in such embodiments, the first rate may be 3000 rpm. And in such embodiments, the first time period may be 28 to 38 seconds. With this arrangement, the thickness of the first sacrificial layer **316** may be formed. The spin cycle may further include accelerating the partially-fabricated device **300c** at a second rate for a second time period before rotating the partially-fabricated device **300c** at the first rate for the first time period. In some embodiments, the second rate may be 1500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying the deceleration cycle comprises decelerating the partially-fabricated device **300c** at a rate for a time period. And in such embodiments, the rate may be 1500 rpm per second. And in such embodiments, the time period may be 2 seconds.

Moreover, in some embodiments, the partially-fabricated device **300c** may be placed in a vacuum chuck before placing the material on the partially-fabricated device **300c**. And in such embodiments, the partially-fabricated device **300c** may be removed from the vacuum chuck after applying the deceleration cycle.

After the first sacrificial layer **316** is spin coated, the first sacrificial layer **316** may be baked before patterning. The first sacrificial layer **316** may be baked in a variety of ways. For example, the first sacrificial layer **316** may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 2 minutes. After the first sacrificial layer **316** is baked, the first sacrificial layer **316** may be cooled to room temperature.

In addition, the first sacrificial layer **316** may be patterned in a variety of ways. For example, a material may be patterned by exposing and developing. In such an example, the material may be exposed to light at an intensity for a first time period, and developed by soaking in a fluid for a second time period. In some embodiments, the light may be ultra violet light (UV light) that is generated by a mercury lamp. Moreover, in some embodiments, the intensity may be 16 to 19 milliwatts per centimeter (mW/cm<sup>2</sup>). Further, in some embodiments, the first time period may be 10 to 12 seconds. Moreover, in some embodiments, the fluid may comprise four parts DI water and one part a fluid comprising potassium borates. And in such embodiments, the fluid comprising potassium borates may be AZ® 400K Developer sold by AZ Electronics Materials. Further still, in some embodiments, the second time period may be about 1 minute.

Moreover, the partially-fabricated device **300d** may be further processed after formation of the first sacrificial layer **316** over the portion **318** of the seed layer **314**. The partially-fabricated device **300d** may be further processed in a variety of ways. For example, the partially-fabricated device **300d** may be further processed by rinsing in a fluid, blow drying with a gas, and baking at a temperature for a time period. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 30 minutes. After the first sacrificial layer **316** is further processed after formation of the first sacrificial layer **316** over the portion **318** of the seed layer **314**, the first sacrificial layer **316** may be cooled to room temperature.

Further, the partially-fabricated device **300c** may be cleaned before forming the first sacrificial layer **316** over the portion **318** of the seed layer **314**. The partially-fabricated device **300c** may be cleaned in a variety of ways. For example, the partially-fabricated device **300c** may be cleaned by soaking in a first fluid, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include IPA. Further, in some embodiments, the gas may include nitrogen.

Further still, the partially-fabricated device **300c** may be baked before forming the first sacrificial layer **316** over the portion **318** of the seed layer **314**. The partially-fabricated device **300c** may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 2 minutes. Further, in some embodiments, the partially-fabricated device **300c** may be baked on a hot plate. After the partially-fabricated device **300c** is baked, the partially-fabricated device **300c** may be cooled to room temperature.

As shown in FIG. 3e, a first metal layer **320** is formed over exposed portions **328** of the seed layer **314** (i.e., the portions that are not covered by the first sacrificial layer **316**) to provide a partially-fabricated device **300e**. The first metal layer **320** defines components including an antenna **322**, electrical contacts **324**, and electrical interconnects **326**.

The first metal layer **320** may include a variety of conductive materials. For example, the first metal layer **320** may include one or more layers of platinum, silver, gold, palladium, titanium, copper, chromium, nickel, aluminum, other metals or conductive materials, and combinations thereof. In some embodiments, the first metal layer **320** may include a substantially transparent conductive material for at least some components (e.g., a material such as indium tin oxide). In an example, the first metal layer **320** may comprise one layer of gold.



Moreover, the first metal layer **320** may have a variety of thicknesses. For example, the first metal layer **320** may have a thickness between 6 to 10 micrometers, such as between 6 to 7 micrometers, 7 to 8 micrometers, or 9 to 10 micrometers. Other thicknesses of the first metal layer **320** are possible as well.

In an example, the first metal layer **320** may be formed by a microfabrication process such as electroplating. Other microfabrication processes for forming the first metal layer **320** are possible as well. The first metal layer **320** may be electroplated in a variety of ways. For example, the first metal layer **320** may be electroplated in a bath at a current for a time period. In some embodiments, the current is 60 milliamps (mA). Moreover, in some embodiments, the time period is 60 to 75 minutes.

Moreover, the partially-fabricated device **300d** may be plasma cleaned before forming the first metal layer **320** over the exposed portions **328** of the seed layer **314**. The partially-fabricated device **300d** may be plasma cleaned in a variety of ways. For example, the partially-fabricated device **300d** may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 5 minutes.

Next, the first sacrificial layer **316** is removed and the portion **318** of the seed layer **314** is removed to provide a partially-fabricated device **300f**, as shown in FIG. 3f. In some embodiments, a gold layer of the portion **318** of the seed layer **314** and/or a palladium layer of the portion **318** of the seed layer **314** may be removed.

The first sacrificial layer **316** may be removed in a variety of ways. For example, the first sacrificial layer **316** may be removed by soaking in a first fluid for a time period, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the time period may be 2 minutes. Further, in some embodiments, the second fluid may include IPA. Further still, in some embodiments, the gas may include nitrogen. And, in an example, removal may further involve agitation during soaking in the first fluid.

In addition, the portion **318** of the seed layer **314** may be removed in a variety of ways. For example, the portion **318** of the seed layer **314** may be removed by wet etching. The gold layer of the portion **318** of the seed layer **314** may be wet etched in a variety of ways. For example, the gold layer of the portion **318** of the seed layer **314** may be wet etched for a time period at a temperature. In some embodiments, the time period may be between 1 to 2 minutes. Moreover, in some embodiments, the temperature may be room temperature. And, in some embodiments, removing the gold layer of the portion **318** of the seed layer **314** may involve agitation (e.g., constant agitation) during wet etching. After the gold layer of the portion **318** of the seed layer **314** is wet etched, removing the gold layer of the portion **318** of the seed layer **314** may involve rinsing in a fluid and drying with a gas. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen.

Moreover, the palladium layer of the portion **318** of the seed layer **314** may be wet etched in a variety of ways. For example, the palladium layer of the portion **318** of the seed layer **314** may be wet etched for a time period at a temperature. In some embodiments, the time period may be 30 seconds. Moreover, in some embodiments, the temperature may be 70 degrees C. After the palladium layer of the portion **318** of the seed layer **314** is wet etched, removing the palladium layer of the portion **318** of the seed layer **314** may involve rinsing in a fluid and drying with a gas. In some

embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen.

As shown in FIG. 3g, a second sacrificial layer **330** is formed over a portion **332** of the first bio-compatible layer **310** and a portion **334** the first metal layer **320** to provide a partially-fabricated device **300g**. The second sacrificial layer **330** may include a variety of materials. For example, the second sacrificial layer **330** may include one or more photoresist layers, such as one photoresist layer comprising 2-ethoxyethyl acetate. In such an example, the second sacrificial layer **330** may be AZ4620® sold by Capital Scientific. In another example, the second sacrificial layer **330** may include one photoresist layer comprising 1-methoxy-2-propanol acetate. In such an example, the second sacrificial layer **330** may be AZ nLOF 2070® sold by AZ Electronic Materials. In yet another example, the second sacrificial layer **330** may include one photoresist layer comprising cyclohexanone. In such an example, the second sacrificial layer **330** may be NR9-3000PY sold by Futurrex, Inc.

Moreover, the second sacrificial layer **330** may have a variety of thicknesses. For example, the second sacrificial layer **330** may have a thicknesses of 5 micrometers. Other thicknesses of the second sacrificial layer **330** are possible as well.

In an example, the second sacrificial layer **330** may be formed over the portion **332** of the first bio-compatible layer **310** and the portion **334** of the first metal layer **320** by spin coating and patterning.

The second sacrificial layer **330** may be spin coated in a variety of ways. For example, a material may be spin coated by placing the material on the partially-fabricated device **300f**, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the material on the partially-fabricated device **300f** may include pouring (or pipetting) the material onto the partially-fabricated device **300f**.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300f** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 8 seconds. With this arrangement, the material may be spread over the partially-fabricated device **300f**. The spread cycle may further include accelerating the partially-fabricated device **300f** at a second rate for a second time period before rotating the partially-fabricated device **300f** at the first rate for the first time period. In some embodiments, the second rate may be 250 rpm. Moreover, in some embodiments, the second time period may be 2 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300f** at a first rate for a first time period. And in such embodiments, the first rate may be 3000 rpm. And in such embodiments, the first time period may be 28 to 38 seconds. With this arrangement, the thickness of the sacrificial layer **316** may be formed. The spin cycle may further include accelerating the partially-fabricated device **300f** at a second rate for a second time period before rotating the partially-fabricated device **300f** at the first rate for the first time period. In some embodiments, the second rate may be 1500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying the deceleration cycle comprises decelerating the partially-fabricated device **300f** at a rate for a time period. And in such

embodiments, the rate may be 1500 rpm per second. And in such embodiments, the time period may be 2 seconds.

Moreover, in some embodiments, the partially-fabricated device **300f** may be placed in a vacuum chuck before placing the material on the partially-fabricated device **300f**. And in such embodiments, the partially-fabricated device **300f** may be removed from the vacuum chuck after applying the deceleration cycle.

After the second sacrificial layer **330** is spin coated, the second sacrificial layer **330** may be baked before patterning. The second sacrificial layer **330** may be baked in a variety of ways. For example, the second sacrificial layer **330** may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 2 minutes. After the second sacrificial layer **330** is baked, the second sacrificial layer **330** may be cooled to room temperature.

In addition, the second sacrificial layer **330** may be patterned in a variety of ways. For example, the material may be patterned by exposing and developing. In such an example, the material may be exposed to light at an intensity for a first time period, and developed by soaking in a fluid for a second time period. In some embodiments, the light may be ultra violet light (UV light) that is generated by a mercury lamp. Moreover, in some embodiments, the intensity may be the intensity may be 16 to 19 mW/cm<sup>2</sup>. Further, in some embodiments, the first time period may be 10 to 12 seconds. Moreover, in some embodiments, the fluid may comprise four parts DI and one part a fluid comprising potassium borates. And in such embodiments, the fluid comprising potassium borates may be AZ® 400K Developer sold by AZ Electronics Materials. Further still, in some embodiments, the second time period may be about 1 minute.

Moreover, the partially-fabricated device **300g** may be further processed after formation of the second sacrificial metal layer **330** over the portion **332** of the first bio-compatible layer **310** and the portion **334** the first metal layer **320**. The partially-fabricated device **300g** may be further processed in a variety of ways. For example, the partially-fabricated device **300g** may be further processed by rinsing in a fluid, blow drying with a gas, and baking at a temperature for a time period. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 30 minutes. After the second sacrificial layer **330** is processed after formation, the second sacrificial layer **330** may be cooled to room temperature.

Further, the partially-fabricated device **300f** may be cleaned before forming the second sacrificial layer **330** over the portion **332** of the first bio-compatible layer **310** and the portion **334** of the first metal layer **320**. The partially-fabricated device **300f** may be cleaned in a variety of ways. For example, the partially-fabricated device **300f** may be cleaned by soaking in a first fluid, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include IPA. Further, in some embodiments, the gas may include nitrogen.

Further still, the partially-fabricated device **300f** may be baked before forming the second sacrificial layer **330** over the portion **332** of the first bio-compatible layer **310** and the portion **334** of the first metal layer **320**. The partially-fabricated device **300f** may be baked at a temperature for a

time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 2 minutes. Further, in some embodiments, the partially-fabricated device **300f** may be baked on a hot plate. After the partially-fabricated device **300f** is baked, the partially-fabricated device **300f** may be cooled to room temperature.

As shown in FIG. **3h**, a second metal layer **336** is formed over exposed portions **344** of the first bio-compatible layer **310** and exposed portions **346** of the first metal layer **320** (i.e., the portions that are not covered by the second sacrificial layer **330**) to provide a partially-fabricated device **300h**. The second metal layer **336** defines electrical interconnects **338** and sensor electrodes **340**.

The second metal layer **336** may include a variety of conductive materials. For example, the second metal layer **336** may include one or more layers of platinum, silver, gold, palladium, titanium, copper, chromium, nickel, aluminum, other metals or conductive materials, and combinations thereof. In an example, the second metal layer may comprise a titanium layer, a palladium layer, and a platinum layer.

Moreover, the second metal layer **336** may have a variety of thicknesses. For example, a titanium layer of the second metal layer **336** may have a thickness between 10 to 50 nanometers, such as 30 nanometers; a palladium layer may of the second metal layer **336** may have a thickness between 10 to 50 nanometers, such as 30 nanometers; and a platinum layer of the second metal layer **336** may have a thickness between 50 to 300 nanometers, such as 100 or 120 nanometers. Other thicknesses of the second metal layer **336** are possible as well.

In an example, the second metal layer **336** may be formed by a microfabrication process such as sputtering. However, in other examples, the second metal layer **336** may be formed by other microfabrication processes such as evaporation. In some embodiments, a titanium layer of the second metal layer **336** may be formed over the exposed portions **344** of the first bio-compatible layer **310** and exposed portions **346** of the first metal layer **320**, a palladium layer of the second metal layer **336** may be formed over the titanium layer, and a platinum layer of the second metal layer **336** may be formed over the palladium layer.

Moreover, the partially-fabricated device **300g** may be plasma cleaned before forming the second metal layer **336** over the exposed portions **344** of the first bio-compatible layer **310** and the exposed portions **346** of the first metal layer **320**. The partially-fabricated device **300g** may be plasma cleaned in a variety of ways. For example, the partially-fabricated device **300g** may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 60 seconds.

Next, the second sacrificial layer **330** is removed to provide a partially-fabricated device **300i**, as shown in FIG. **3i**. The second sacrificial layer **330** may be removed in a variety of ways. For example, the second sacrificial layer **330** may be removed by soaking in a first fluid for a first time period, rinsing in a second fluid, drying with a gas, and baking at a temperature for a second time period. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the first time period may be 1 to 5 hours, such as 1 to 2 hours or 4 to 5 hours. Further, in some embodiments, the second fluid may include IPA. Further still, in some embodiments, the gas may include nitrogen. Moreover, in some embodiments, the temperature may be 90 degrees C. Further, in some embodiments, the second time period may be 5 minutes. And, in an example, removal may

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further involve sonication for a time period (e.g., 2 to 3 seconds) after soaking in the first fluid. For instance, in some embodiments, removal may involve sonication for the time period after soaking in the first fluid for 1 hour.

After the second sacrificial layer **330** is removed, the partially-fabricated device **300i** may be rinsed in a fluid, dried with a gas, and baked at a temperature for a time period. In some embodiments, the fluid may include IPA. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 5 minutes.

Together, the first metal layer **320** and the second metal layer **336** are a conductive pattern **342**. The conductive pattern **342** defines the antenna **332**, the electrical contacts **324**, the electrical interconnects **326**, the electrical interconnects **338**, and the sensor electrodes **340**.

As shown in FIG. 3j, a protective layer **348** is formed over the sensor electrodes **340** to provide a partially-fabricated device **300j**. The protective layer **348** may include a variety of materials. For example, the protective layer **348** may include one or more photoresist layers, such as one photoresist layer comprising 2-ethoxyethyl acetate. In such an example, the protective layer **348** may be AZ6420® sold by Capital Scientific. However, in other examples, the protective layer **348** may include one or more layers of metal, such as aluminum.

Moreover, the protective layer **348** may have a variety of thicknesses. For example, the protective layer **348** may have a thickness of 40 micrometers. Other thicknesses of the protective layer **348** are possible as well.

In an example, the protective layer **348** may be formed over the sensor electrodes **340** by spin coating and patterning. However, in other examples, the protective layer **348** may be formed by microfabrication processes such as evaporation and/or sputtering.

The protective layer **348** may be spin coated in a variety of ways. For example, the protective layer **348** may be spin coated in steps. In such an example, a first step may involve placing a first material on the partially-fabricated device **300i**, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the first material on the partially-fabricated device **300i** may include pouring (or pipetting) the first material onto the partially-fabricated device **300i**.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300i** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 5 to 8 seconds. With this arrangement, the first material may be spread over the sensor electrodes **340**. The spread cycle may further include accelerating the partially-fabricated device **300i** at a second rate for a second time period before rotating the partially-fabricated device **300i** at the first rate for the first time period. In some embodiments, the second rate may be 100 to 250 rpm per second. Moreover, in some embodiments, the second time period may be 2 to 5 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300i** at a first rate for a first time period. And in such embodiments, the first rate may be 900 to 1000 rpm. And in such embodiments, the first time period may be 38 to 118 seconds. With this arrangement, a first portion of the thickness of the protective layer **348** may be formed. The spin cycle may further include accelerating the partially-fabricated device

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**300i** at a second rate for a second time period before rotating the partially-fabricated device **300i** at the first rate for the first time period. In some embodiments, the second rate may be 450 to 500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying deceleration cycle comprises decelerating the partially-fabricated device **300i** at a rate for a time period. And in such embodiments, the rate may be 450 to 500 rpm per second. And in such embodiments, the time period may be 2 seconds.

Moreover, in some embodiments, the partially-fabricated device **300i** may be placed in a vacuum chuck before placing the first material on the partially-fabricated device **300i**.

After the first step, the first material may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 1 minute.

In such an example, a second step may involve placing a second material on the first material, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the second material on the first material may include pouring (or pipetting) the second material onto the first material.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300i** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 5 to 8 seconds. With this arrangement, the second material may be spread over the first material. The spread cycle may further include accelerating the partially-fabricated device **300i** at a second rate for a second time period before rotating the partially-fabricated device **300i** at the first rate for the first time period. In some embodiments, the second rate may be 100 to 250 rpm per second. Moreover, in some embodiments, the second time period may be 2 to 5 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300i** at a first rate for a first time period. And in such embodiments, the first rate may be 900 to 1000 rpm. And in such embodiments, the first time period may be 38 to 118 seconds. With this arrangement, a second portion of the thickness of the protective layer **348** may be formed. The spin cycle may further include accelerating the partially-fabricated device **300i** at a second rate for a second time period before rotating the partially-fabricated device **300i** at the first rate for the first time period. In some embodiments, the second rate may be 450 to 500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying deceleration cycle comprises decelerating the partially-fabricated device **300i** at a rate for a time period. And in such embodiments, the rate may be 450 to 500 rpm per second. And in such embodiments, the time period may be 2 seconds.

And in some embodiments, the partially-fabricated device **300i** may be removed from the vacuum chuck after applying the deceleration cycle.

After the second step, the first and second material may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 10 minutes. And such an example may further involve baking the first and second materials until room temperature at a rate. In some embodiments, the rate may be 2 degrees C. per minute.

In addition, the protective layer **348** may be patterned in a variety of ways. For example, the first and second material

may be patterned by exposing and developing. And, in such an example, the first and second material may be exposed and developed in steps.

In such an example, a first step may involve exposing the first and second material to light at an intensity for a first time period. In some embodiments, the light may be ultra violet light (UV light) that may be generated by a mercury lamp. Moreover, in some embodiments, the intensity may be the intensity may be 16 to 19 mW/cm<sup>2</sup>. Further, in some embodiments, the first time period may be 26 seconds. Moreover, in such an example, a second step may involve repeating the first step. In another example, the first time period may include one or more cycles (e.g., 4 cycles) where each of the one or more cycles includes an exposure time period (e.g., 20 seconds) and waiting time period (e.g., 30 seconds to 2 minutes).

Further, in such an example, a third step may involve developing the first and second material by soaking in a fluid for a second time period. In some embodiments, the fluid may comprise four parts DI and one part a fluid comprising potassium borates. And in such embodiments, the fluid comprising potassium borates may be AZ® 400K Developer sold by AZ Electronics Materials. Moreover, in some embodiments, the second time period may be 4 minutes. Further still, in such an example, a fourth step may involve repeating the third step.

Moreover, the partially-fabricated device 300j may be further processed after formation of the protective layer 348 over the sensor electrodes 340. The protective layer 348 may be further processed in a variety of ways. For example, the protective layer 348 may be further processed by rinsing in a fluid and drying with a gas. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen.

In such an example, the partially-fabricated device 300j may then baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 20 minutes.

Further, the partially-fabricated device 300i may be cleaned before forming the protective layer 348 over the sensor electrodes 340. The partially-fabricated device 300i may be cleaned in a variety of ways. For example, the partially-fabricated device 300i may be cleaned by soaking in a first fluid, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include IPA. Further, in some embodiments, the gas may include nitrogen.

Further still, the partially-fabricated device 300i may be baked before forming the protective layer 348 over the sensor electrodes 340. The partially-fabricated device 300i may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 5 minutes. Further, in some embodiments, the partially-fabricated device 300i may be baked on a hot plate. After the partially-fabricated device 300i is baked, the partially-fabricated device 300i may be cooled to room temperature.

Next, an electronic component 350 is mounted to the electrical contacts 324 to provide a partially-fabricated device 300k, as shown in FIG. 3k. The electronic component 350 could include, for example, one or more integrated circuits (ICs) and/or one or more discrete electronic components. Heat, pressure, a pick-and-place tool and a bonding medium (anisotropic conductive paste (ACP), anisotropic conductive film (ACF), solder and flux, solder paste, solder

followed by underfill, etc.), or a flip-chip bonder, for example, may be used to adhere a first surface 352 of the electronic component 350 to the electrical contacts 324. The electronic component 350 has a second surface 354 opposite the first surface 362.

As shown in FIG. 3l, a surface 356 of the first bio-compatible layer 310 is treated to provide a partially-fabricated device 300l, such that a surface of another bio-compatible layer, such as a second bio-compatible layer, bonds to the surface during formation of the other bio-compatible layer. The surface 356 of the first bio-compatible layer 310 may be treated in a variety of ways. For example, the surface 356 of the first bio-compatible layer 310 may be treated by etching using an inductively coupled plasma at a power for a time period. With this arrangement, the surface 356 of the first bio-compatible layer 310 may be roughened. In some embodiments, the inductively coupled plasma may include an oxygen plasma. Moreover, in some embodiments, the power may be 400 W with a 300 W bias. Further, in some embodiments, the time period may be 1 minute. Other plasmas and/or types of plasmas may be used as well, such as a plasma asher, a reactive ion etcher, etc.

The partially-fabricated device 300k may be baked at a temperature for a time period before treating the surface 356 of the first bio-compatible layer 310. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 1 hour.

As shown in FIG. 3m, a second bio-compatible layer 358 is formed over the first bio-compatible layer 310, the electronic component 350, the antenna 322, the electrical interconnects 338, the protective layer 348, the electrical contacts 324, and the electrical interconnects 326 to provide a partially-fabricated device 300m. The second bio-compatible layer 358 defines a second side 360 of the bio-compatible device. That is, the second bio-compatible layer 358 defines an outer edge of the bio-compatible device.

In an example, the second bio-compatible layer 358 can be composed of the same polymeric material as the first bio-compatible layer 310. However, in other examples, the second bio-compatible layer 358 can be composed of a different polymeric material than the first bio-compatible 310. The second bio-compatible layer 358 can be any one of the polymeric materials mentioned herein that is both bio-compatible and electrically insulating. The second layer of bio-compatible material 370 thus serves to seal and insulate the components.

Moreover, the second bio-compatible layer 358 may have a variety of thicknesses. For example, the second bio-compatible layer 358 may have a thickness between one or more embedded components and a surface of the second bio-compatible layer 358 between 5 to 100 micrometers, such as 15 micrometers. Other thicknesses for the second bio-compatible layer 358 are possible as well.

In an example, the second bio-compatible layer 358 may be formed the same or similar way as the first bio-compatible layer 310 may be formed. However, in other examples, the second bio-compatible layer 358 may be formed by a different process (or processes) than the process (or processes) used to form the first bio-compatible layer 310.

For example, the second bio-compatible layer 358 may be formed by a microfabrication process such as chemical vapor deposition. The deposition of the second bio-compatible layer 358 may result in a conformal coating over the assembled components. Moreover, in an example, 35 grams of a polymeric material may be used to form the second bio-compatible layer 358.

The second bio-compatible layer **358** may be deposited to create a continuous layer that spans the entirety of the assembled components. The second bio-compatible layer **358** can span a region that extends beyond a footprint of the assembled components. As a result, the assembled components can be surrounded by portions of the second bio-compatible layer **358** that rest directly on the first bio-compatible layer **310**.

Additionally or alternatively, after the second bio-compatible layer **358** is formed over first bio-compatible layer **310**, the electronic component **350**, the antenna **322**, the electrical interconnects **338**, the protective layer **348**, the electrical contacts **324**, and the electrical interconnects **326**, the first bio-compatible layer **310** and the second bio-compatible layer **358** may be annealed and/or sintered. With this arrangement, the second bio-compatible layer **358** may bond to the first bio-compatible layer **310**.

Moreover, the partially-fabricated device **300l** may be cleaned before forming the second bio-compatible layer **358** over the first bio-compatible layer **310**, the electronic component **350**, the antenna **322**, the electrical interconnects **338**, the protective layer **348**, the electrical contacts **324**, and the electrical interconnects **326**. The partially-fabricated device **300l** may be cleaned in a variety of ways. For example, the partially-fabricated device **300l** may be cleaned by rinsing in a fluid, drying with a gas, and baking at a temperature for a time period. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 60 minutes.

Further, the partially-fabricated device **300l** may be plasma cleaned before forming the second bio-compatible layer **358** over the first bio-compatible layer **310**, the electronic component **350**, the antenna **322**, the electrical interconnects **338**, the protective layer **348**, the electrical contacts **324**, and the electrical interconnects **326**. The partially-fabricated device **300l** may be plasma cleaned in a variety of ways. For example, the partially-fabricated device **300l** may be plasma cleaned at a power for a time period. In some embodiments, the power may be high. Moreover, in some embodiments, the time period may be 5 minutes.

Next, an etch mask **362** is formed over a portion **363** of the second bio-compatible layer **358** to provide a partially-fabricated device **300n**, as shown in FIG. **3n**. The etch mask **362** may include a variety of materials. For example, the etch mask **362** may include one or more photoresist layers, such as one photoresist layer comprising cyclopentanone. In such an example, the etch mask **362** may be KMPR® sold by Micro Chem. However, in other examples, the etch mask **362** may include one or more metal layers and/or one or more nitride layers.

Moreover, the etch mask **362** may have a variety of thicknesses. For example, the etch mask **362** may have a thickness between 100 to 150 micrometers, such as 120 or 130 micrometers. Other thicknesses of the etch mask **362** are possible as well.

In an example, the etch mask **362** may be formed by spin coating and patterning. However, in other examples, the etch mask **362** may be formed by microfabrication processes such as evaporation and/or sputtering.

The etch mask **362** may be spin coated in a variety of ways. For example, the etch mask **362** may be spin coated in steps. In such an example, a first step may involve placing

a first material on the partially-fabricated device **300m**, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the first material on the partially-fabricated device **300m** may include pouring (or pipetting) the first material onto the partially-fabricated device **300m**.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300m** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 5 seconds. With this arrangement, the first material may be spread over the partially-fabricated device **300m**. The spread cycle may further include accelerating the partially-fabricated device **300m** at a second rate for a second time period before rotating the partially-fabricated device **300m** at the first rate for the first time period. In some embodiments, the second rate may be 100 rpm per second. Moreover, in some embodiments, the second time period may be 5 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300m** at a first rate for a first time period. And in such embodiments, the first rate may be 1000 rpm. And in such embodiments, the first time period may be 38 to 118 seconds. With this arrangement, a first portion of the thickness of the etch mask **362** may be formed. The spin cycle may further include accelerating the partially-fabricated device **300m** at a second rate for a second time period before rotating the partially-fabricated device **300m** at the first rate for the first time period. In some embodiments, the second rate may be 500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying the deceleration cycle comprises decelerating the partially-fabricated device **300m** at a rate for a time period. And in such embodiments, the rate may be 500 rpm per second. And in such embodiments, the time period may be 2 seconds.

Moreover, in some embodiments, the partially-fabricated device **300m** may be placed in a vacuum chuck before placing the first material on the partially-fabricated device **300m**.

The first step may further involve baking the first material at a temperature for a time period. In some embodiments, the temperature is 90 degrees C. Moreover, in some embodiments, the time period may be 5 minutes.

In such an example, a second step may involve placing a second material on the first material, applying a spread cycle, applying a spin cycle, and applying a deceleration cycle.

In some embodiments, placing the second material on the first material may include pouring (or pipetting) the second material onto the first material.

Moreover, in some embodiments, applying the spread cycle may include rotating the partially-fabricated device **300m** at a first rate for a first time period. And in such embodiments, the first rate may be 500 rpm. And in such embodiments, the first time period may be 5 seconds. With this arrangement, the second material may be spread over the first material. The spread cycle may further include accelerating the partially-fabricated device **300m** at a second rate for a second time period before rotating the partially-fabricated device **300m** at the first rate for the first time period. In some embodiments, the second rate may be 100 rpm per second. Moreover, in some embodiments, the second time period may be 5 seconds.

Further, in some embodiments, applying the spin cycle may include rotating the partially-fabricated device **300/** at a first rate for a first time period. And in such embodiments, the first rate may be 1000 rpm. And in such embodiments, the first time period may be 38 to 118 seconds. With this arrangement, a second portion of the thickness of the etch mask **362** may be formed. The spin cycle may further include accelerating the partially-fabricated device **300m** at a second rate for a second time period before rotating the partially-fabricated device **300m** at the first rate for the first time period. In some embodiments, the second rate may be 500 rpm per second. Moreover, in some embodiments, the second time period may be 2 seconds.

Further still, in some embodiments, applying deceleration cycle comprises decelerating the partially-fabricated device **300m** at a rate for a time period. And in such embodiments, the rate may be 500 rpm per second. And in such embodiments, the time period may be 2 seconds.

And in some embodiments, the partially-fabricated device **300m** may be removed from the vacuum chuck after applying the deceleration cycle.

After the first and second material is spin coated, the first and second material may be baked at a first temperature to a second temperature at a rate for a time period. In some embodiments, the first temperature is 65 degrees C. Moreover, in some embodiments, the second temperature is 90 to 95 degrees C. Further, in some embodiments, the rate is 120 degrees C. per hour. Further still, in some embodiments, the time period may be 1 hour. In another example, the first and second material may be baked at 90 degrees C. for 1 hour.

After the first and second material is baked, the first and second material may be cooled to room temperature at a rate. In some embodiments, the rate is 450 degrees C. per hour or 120 degrees C. per hour.

The etch mask may **362** be patterned in a variety of ways. For example, the first and second material may be patterned by exposing and developing. And, in such an example, the first and second material may be exposed and developed in steps.

In such an example, a first step may involve exposing the first and second material to light at an intensity for a first time period. In some embodiments, the light may be ultra violet light (UV light) that may be generated by a mercury lamp. Moreover, in some embodiments, the intensity may be the intensity may be 16 to 19 mW/cm<sup>2</sup>. Further, in some embodiments, the first time period may be 30 seconds. Moreover, in such an example, a second step may involve repeating the first step. In another example, the first time period may include one or more cycles (e.g., 3 cycles) where each of the one or more cycles includes an exposure time period (e.g., 20 seconds) and a waiting time period (e.g., 30 seconds to 2 minutes)

Further, in such an example, a third step may involve baking the first and second material at a temperature for a second time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the second time period may be 2 minutes. Further still, in such an example, a fourth step may involve developing the first and second material using a fluid comprising 1-methoxy-2-propyl acetate. In such an example, the fluid may be SU-8 Developer® sold by Micro Chem. In some embodiments, the time period may be 15 or 10 minutes.

Moreover, the partially-fabricated device **300n** may be further processed after formation of the etch mask **362** over the portion **363** of the second bio-compatible layer **358**. The partially-fabricated device **300n** may be further processed in a variety of ways. For example, the partially-fabricated

device **300n** may be further processed by rinsing in a fluid, blow drying with a gas, and baking at a temperature for a time period. In some embodiments, the fluid may include IPA. Moreover, in some embodiments, the gas may include nitrogen. Further, in some embodiments, the temperature may be 90 degrees C. Further still, in some embodiments, the time period may be 60 minutes.

Moreover, the partially-fabricated device **300m** may be cleaned before forming the etch mask **362** over the portion **363** of the second bio-compatible layer **358**. The partially-fabricated device **300m** may be cleaned in a variety of ways. For example, the partially-fabricated device **300m** may be cleaned by soaking in a first fluid, rinsing in a second fluid, and drying with a gas. In some embodiments, the first fluid may include acetone. Moreover, in some embodiments, the second fluid may include IPA. Further, in some embodiments, the gas may include nitrogen.

Further, the partially-fabricated device **300m** may be baked before forming the etch mask **362** over the portion **363** of the second bio-compatible layer **358**. The partially-fabricated device **300m** may be baked in a variety of ways. For example, the partially-fabricated device **300m** may be baked at a temperature for a time period. In some embodiments, the temperature may be 90 degrees C. Moreover, in some embodiments, the time period may be 5 minutes.

As shown in FIG. 3o, exposed portions **364** of the second bio-compatible layer **358** (i.e., the portions that are not covered by the etch mask **362**) are removed to provide a partially-fabricated device **300o**. In an example, the exposed portions **364** of the second bio-compatible layer **358** are removed by etching using an inductively coupled plasma at a power for a time period. In some embodiments, the inductively coupled plasma may include an oxygen plasma. Moreover, in some embodiments, the power may be 400 W at a 300 W bias. Further, in some embodiments, the time period may be 33 minutes. And, in such an example, the etching may comprise one or more cycles that comprises an etch period followed by a rest period, such that the partially-fabricated device **300n** may cool down. In some embodiments, the etch period may be 3 minutes. Moreover, in some embodiments, the rest period may be 2 minutes. Further, in some embodiments, the one or more cycles may be 11 cycles. And, in some embodiments, the one or more cycles may be applied in sequence. Other plasmas and/or types of plasmas may be used as well, such as a plasma asher, a reactive ion etcher, etc.

In such an example, a first portion **364A** of the exposed portions **364** of the second bio-compatible layer **358** that is located above the protective layer **348** is etched to thereby form an opening **370** in the second bio-compatible layer **358**. In some embodiments, the opening **370** may have a dimension of between 500 to 700 micrometers. The opening **370** may have a variety of shapes, such as a square shape with rounded corners, a rectangular shape, a circular shape, etc.

Moreover, in such an example, a second portion **364B** of the exposed portions **364** of the second bio-compatible layer **358** are etched through to the sacrificial metal layer **304** thereby leaving excess material **372**. With this approach, the etch mask **362** may define a shape **366** of the bio-compatible device and/or a shape **368** of the antenna **322**.

Further, as illustrated in FIG. 3o, at least a portion of the protective layer **348** is removed thereby leaving a portion **348B** of the protective layer **348**. In an example, the portion of the protective layer **348** is removed by the inductively coupled plasma that etches the exposed portions **364** of the second bio-compatible layer **358**. In some embodiments, the portion of the protective layer **348** that is etched may have

a thickness between 20 and 30 micrometers. And, as illustrated in FIG. 30, at least a portion of the etch mask 362 is removed thereby leaving a portion 362B of the etch mask 362. In an example, the portion of the etch mask 362 is removed by the inductively coupled plasma that etches the exposed portions 364 of the second bio-compatible layer 358.

Next, the portion 348B of the protective layer 348 is removed to thereby expose the sensor electrodes 340 to provide a partially-fabricated device 300p, as shown in FIG. 3p. The portion 348B of the protective layer 348 may be removed in a variety of ways. For example, the portion 348B of the protective layer 348 may be removed by dissolving the portion 348B of the protective layer 348 in a fluid at temperature for a time period. In some embodiments, the fluid may comprise n-methyl pyrrolidinone. And in such embodiments, the fluid may be Remover PG® sold by Micro Chem. Moreover, in some embodiments, the temperature may be 90 degrees C. Further, in some embodiments, the time period may be 5 minutes.

Moreover, in an example, removal may further involve rinsing in a fluid and drying with a gas. In some embodiments, the fluid may include IPA. Moreover, in some embodiments, the gas may include nitrogen.

As shown in FIG. 3q, the sacrificial metal layer 304 is removed to release the bio-compatible device 300q from the working substrate 302. The sacrificial metal layer 304 may be removed in a variety of ways. For example, the sacrificial metal layer 304 may be removed by dissolving the sacrificial metal layer 304 in a fluid at a temperature for a time period. In some embodiments, the fluid may comprise four parts DI and one part a fluid comprising potassium borates. And in such embodiments, the fluid comprising potassium borates may be AZ® 400K Developer sold by AZ Electronics Materials. Moreover, in some embodiments, the temperature may be room temperature. Further, in some embodiments, the time period may be 5 minutes or multiple hours, such as 6 to 10 hours.

Moreover, in an example, removal may further involve soaking in a fluid, rinsing with a fluid, and drying. In some embodiments, the fluid may include DI water. Moreover, in some embodiments, drying may involve hand drying on a towel.

As illustrated in FIG. 3q, the bio-compatible device 300q includes the first bio-compatible layer 310, the antenna 322, the electrical contacts 324, the electrical interconnects 326, the electrical interconnects 338, the sensor electrodes 340, the second bio-compatible layer 358, the opening 370, the first side 312 of the bio-compatible device, and the second side 360 of the bio-compatible device. The first bio-compatible layer 310 and the second bio-compatible layer 358 encapsulates the assembled components, except the sensor electrodes 340 are exposed by the opening 370.

The bio-compatible device 300q is suitable for incorporation into a biological environment, such as within a body-mountable device or an implantable medical device, for example. Due to the encapsulating bio-compatible material, the surrounding environment is sealed from the embedded components. For example, if the bio-compatible device 300q is implanted in a biological host, or placed in an eye-mountable device to be exposed to tear fluid, the bio-compatible device 300q is able to be exposed to fluids of the biological host (e.g., tear fluid, blood, etc.), because the entire exterior surface is coated with bio-compatible material, except that the sensor electrodes 340 are exposed to allow detection of one or more analytes in the fluid.

The description in FIGS. 3a-q describes one example of a process for fabricating a bio-compatible device that can be embedded in an eye-mountable device. However, the process described with reference to FIGS. 3a-q may be employed to create bio-compatible devices for other applications, such as other mountable devices or implantable electronic medical device applications. Such implantable electronic medical devices may include an antenna for communicating information (e.g., sensor results) and/or inductively harvesting energy (e.g., radio frequency radiation). Implantable electronic medical devices may also include electrochemical sensors or they may include other electronic devices. The process described with reference to FIGS. 3a-q may be used to create bio-compatible devices suitable to be mounted on or in another part of the body, such as the skin, a tooth, or on a tissue in the mouth, for example.

FIG. 4 illustrates a device (or a partially-fabricated device) 400 according to an example embodiment. In particular, the device 400 includes a conductive pattern 402 that defines an antenna 404, electrical interconnects 405, sensor electrodes 406, electrical contacts 408, and electrical interconnects 410; a protective layer 412 over the sensor electrodes 406; an electronic component 414 mounted to the electrical contacts 408; and a bio-compatible layer 416 over the electronic component 414, the antenna 404, the protective layer 412, the electrical contacts 408, and the electrical interconnects 410. The bio-compatible layer 416 defines a first side 418 and a second side 420 of a bio-compatible device.

As illustrated in FIG. 4, the sensor electrodes 406 are covered by the protective layer 412. Moreover, as illustrated in FIG. 4 the antenna 404, the electrical interconnects 405, the protective layer 412, the electrical contacts 408, and the electrical interconnects 410 are covered by the bio-compatible layer 416.

In some embodiments, the conductive pattern 402 may take the form or be similar in form to the conductive pattern 342; the antenna 404 may take the form or be similar in form to the antenna 322; the sensor electrodes 406 may take the form of or be similar in form to the sensor electrodes 340, the electrical contacts 408 may take the form of or be similar in form to the electrical contacts 324; the electrical interconnects 410 may take the form of or be similar in form to the electrical interconnects 326; the protective layer 412 may take the form of or be similar in form to the protective layer 348; the electronic component 414 may take the form of or be similar in form to the electronic component 350; the bio-compatible layer 416 may take the form of or be similar in form to the first bio-compatible layer 310 and the second bio-compatible layer 358; the first side 418 of the bio-compatible device may take the form of or be similar in form to the first side 312 of the bio-compatible device; and/or the second side 420 of the bio-compatible device may take the form of or be similar in form to the second side 360 of the bio-compatible device.

In some embodiments, a portion of the bio-compatible layer 416 is configured to be etched by an inductively coupled plasma (e.g., an oxygen plasma) to form an opening in the bio-compatible layer. Moreover, in at least one such embodiment, the protective layer 412 is configured to be removed through the opening in the bio-compatible layer 416 to thereby expose the sensor electrodes 406, and at least a portion of the protective layer 412 is configured to be etched by the inductively coupled plasma. Further, in at least one such embodiment, the protective layer 412 is configured to be removed through the opening in the bio-compatible

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layer **416** to thereby expose the sensor electrodes **406**, and at least portion of the protective layer **412** is configured to be dissolved in a fluid.

FIG. **5** is a flowchart of a method **500** for fabricating a bio-compatible device, according to an example embodiment. The method **500** may involve forming a first bio-compatible layer (block **502**). The first bio-compatible layer defines a first side of a bio-compatible device. The first bio-compatible layer may be the same as or similar to the first bio-compatible layer **310**. Moreover, the first bio-compatible layer may be formed the same or similar way as the first bio-compatible layer **310** may be formed as described with reference to FIG. **3b**. For instance, in some embodiments, the first bio-compatible layer may comprise paralyene.

The method **500** may involve forming a conductive pattern on the first bio-compatible layer (block **504**). The conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects. The conductive pattern may be the same as or similar to the conductive pattern **342** and/or the conductive pattern **402**, the antenna may be the same as or similar to the antenna **322** and/or the antenna **404**, the electrical contacts may be the same as or similar to the electrical contacts **324** and/or the electrical contacts **408**, and the one or more electrical interconnects may be the same as or similar to the electrical interconnects **326**, the electrical interconnects **338**, the electrical interconnects **405**, and/or the electrical interconnects **410**.

The method **500** may involve forming a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer (block **506**). The protective layer may be the same as or similar to the protective layer **348** and/or the protective layer **412**. Moreover, the protective layer may be formed the same or similar way as the protective layer **348** may be formed as described with reference to FIG. **3j**.

The method **500** may involve mounting an electronic component to the electrical contacts (block **508**). The electronic component may be the same as or similar to the electronic component **350** and/or the electronic component **414**. Moreover, the electronic component may be mounted to the electrical contacts the same or similar way as the electronic component **350** may be mounted to the electrical contacts **324** as described with reference to FIG. **3k**. For instance, in some embodiments, mounting an electronic component to the electrical contacts may comprise bonding the electronic component to the electrical contacts using anisotropic conductive paste.

The method **500** may involve forming a second bio-compatible layer over the first bio-compatible layer, the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects (block **510**). The second bio-compatible layer defines a second side of the bio-compatible device. The second bio-compatible layer may be the same as or similar to the second bio-compatible layer **358**. Moreover, the second bio-compatible layer may be formed the same or similar way to as the second bio-compatible layer may be formed as described with reference to FIG. **3m**. For instance, in some embodiments, the second bio-compatible layer may comprise paralyene.

The method **500** may involve removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer (block **512**). The opening may be the same or similar to the opening **370**. The portion of the second bio-compatible layer may be removed to form an

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opening in the second bio-compatible layer the same or similar way as a portion of the second bio-compatible layer **358** may be removed to form the opening **370** in the second bio-compatible layer **358** as described with reference to FIGS. **3n-o**. For instance, in some embodiments, the opening may have a dimension between 500 to 700 micrometers.

Moreover, in some embodiments, removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer comprises forming an etch mask over the second bio-compatible layer, wherein the etch mask exposes the portion of the second bio-compatible layer; and etching, using an inductively coupled plasma, the portion of the second bio-compatible layer exposed by the etch mask to thereby form the opening. Further, in some embodiments, the etch mask may define a shape of the bio-compatible device. Further still, in some embodiments, the etch mask may define a shape of the antenna. The etch mask may be same as or similar to the etch mask **362**, and the inductively coupled plasma may be the same as or similar to the inductively coupled plasma described with reference to FIG. **3o**.

The method **500** may involve removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes (block **514**). The protective layer may be removed through the opening in the second bio-compatible layer to thereby expose the sensor electrodes in the same or similar way as the protective layer **348** may be removed through the opening **370** in the second bio-compatible layer **358** to thereby expose the sensor electrodes **348** as described with reference to FIGS. **3o-p**.

For instance, in some embodiments, removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes comprises etching, using the inductively coupled plasma, at least a portion of the protective layer through the opening in the second bio-compatible layer. Moreover, in some embodiments, removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes comprises dissolving at least a portion of the protective layer in a fluid. The fluid may be the same as or similar to the fluid used to dissolve the portion **348B** of the protective layer **348** described with reference to FIG. **3p**.

The method **500** may further involve forming a sacrificial metal layer on a working substrate, wherein the first bio-compatible layer is formed on the sacrificial metal layer; and removing the sacrificial metal layer to release the bio-compatible device from the working substrate. The working substrate may be the same as or similar to the working substrate **302**, and the sacrificial metal layer may be the same as or similar to the sacrificial metal layer **304**. The sacrificial metal layer may be formed the same or similar way as the sacrificial metal layer **304** may be formed as described with reference to FIG. **3a**. Moreover, the sacrificial metal layer may be removed to release the bio-compatible device from the working substrate the same or similar way as the sacrificial metal layer **304** may be removed to release the bio-compatible device **300q** from the working substrate **302** as described with reference to FIG. **3q**.

For instance, in some embodiments, the sacrificial metal layer comprises at least one metal layer that adheres to the working substrate. Moreover, in some embodiments, the sacrificial metal layer comprises at least one metal layer that bonds to the first bio-compatible layer. Further, in some embodiments, removing the sacrificial metal layer to release the bio-compatible device from the working substrate comprises dissolving the sacrificial metal layer in a fluid. The



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fluid may be the same as or similar to the fluid used to dissolve the sacrificial metal layer **304** described with reference to FIG. **3g**.

The method **500** may further involve treating a surface of the first bio-compatible layer, such that a surface of the second bio-compatible layer bonds to the surface of the first bio-compatible layer during formation of the second bio-compatible layer. The surface of the first bio-compatible layer may be the same as or similar to the surface **356** of the first bio-compatible layer **310**. The surface of the first bio-compatible layer may be treated the same or similar way as the surface **356** of the first bio-compatible layer **310** may be treated as described with reference to FIG. **3l**.

For instance, in some embodiments, treating the surface of the first bio-compatible layer comprises treating the surface of the first bio-compatible layer with an inductively coupled plasma. The inductively coupled plasma may be the same as or similar to the inductively coupled plasma used to treat the surface **356** of the first bio-compatible layer **310** as described with reference to FIG. **3l**.

FIG. **6** is a flow chart illustrating a method **600** for forming a conductive pattern, according to an example embodiment. The method **600** may be performed in connection with block **504** of method **500**. The method **600** may involve forming a seed layer over the first bio-compatible layer (block **602**). The seed layer may be the same as or similar to the seed layer **314**. The seed layer may be formed the same or similar way as the seed layer **314** may be formed as described with reference to FIG. **3c**.

The method **600** may involve forming a first sacrificial layer over a portion of the seed layer (block **604**). The first sacrificial layer may be the same as or similar to the first sacrificial layer **316**. The first sacrificial layer may be formed the same or similar way as the first sacrificial layer **316** may be formed as described with reference to FIG. **3d**.

The method **600** may involve forming a first metal layer over portions of the seed layer not covered by the first sacrificial layer (block **606**). The first metal layer defines the antenna, the electrical contacts, and at least one electrical interconnects of the one or more electrical interconnects. The first metal layer may be the same as or similar to the first metal layer **320**. The first metal layer may be formed the same or similar way as the first metal layer **320** may be formed as described with reference to FIG. **3e**.

The method **600** may involve removing the first sacrificial layer (block **608**). The first sacrificial layer may be removed in the same or similar way as the first sacrificial layer **316** may be removed as described with reference to FIG. **3f**.

The method **600** may involve removing portions of the seed layer not covered by the first metal layer (block **610**). The portions of the seed layer not covered by the first metal layer may be removed the same or similar way as the portion **318** of the seed layer **314** is removed as described with reference to FIG. **3f**.

The method **600** may involve forming a second sacrificial metal layer over a portion of the first bio-compatible layer and a portion of the first metal layer (block **612**). The second sacrificial layer may be the same as or similar to the second sacrificial layer **330**. The second sacrificial layer may be formed the same or similar way as the second sacrificial layer **330** may be formed as described with reference to FIG. **3g**.

The method **600** may involve forming a second metal layer over portions of the first bio-compatible layer and portions of the first metal layer not covered by the second sacrificial layer (block **614**). The second metal layer defines the sensor electrodes and at least one electrical interconnects

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of the one or more electrical interconnects. The second metal layer may be the same as or similar to the second metal layer **336**. The second metal layer may be formed the same or similar way as the second metal layer **336** may be formed as described with reference to FIG. **3h**.

The method **600** may involve removing the second sacrificial layer (block **616**). The second sacrificial layer may be removed the same or similar way as the second sacrificial layer **330** may be removed as described with reference to FIG. **3i**.

The method **600** may further involve forming a third sacrificial layer over the first metal layer. In some embodiments, the third sacrificial layer may be formed over the first metal layer before removing portions of the seed layer not covered by the first metal layer. The third sacrificial layer may be the same or similar to the first sacrificial layer and/or the second sacrificial layer. The third sacrificial layer may be formed the same or similar way as the first sacrificial layer may be formed and/or the second sacrificial layer may be formed.

The method **600** may further involve removing the third sacrificial layer. In some embodiments, the third sacrificial layer may be removed after removing portions of the seed layer not covered by the first metal layer. The third sacrificial layer may be removed the same or similar way as the first sacrificial layer may be removed and/or the second sacrificial layer may be removed.

FIG. **7** depicts a computer-readable medium configured according to an example embodiment. In example embodiments, the example system can include one or more processors, one or more forms of memory, one or more input devices/interfaces, one or more output devices/interfaces, and machine-readable instructions that when executed by the one or more processors cause a system to carry out the various functions, tasks, capabilities, etc., described above.

In some embodiments, the disclosed techniques can be implemented by computer program instructions encoded on a non-transitory computer-readable storage media in a machine-readable format, or on other non-transitory media or articles of manufacture. FIG. **7** is a schematic illustrating a conceptual partial view of a computer program product **700** that includes a computer program for executing a computer process on a computing device, to perform any of the methods described herein.

In one embodiment, the computer program product **700** is provided using a signal bearing medium **702**. The signal bearing medium **702** may include one or more programming instructions **704** that, when executed by one or more processors may provide functionality or portions of the functionality described above with respect to FIGS. **1-6**. In some examples, the signal bearing medium **702** can include a non-transitory computer-readable medium **706**, such as, but not limited to, a hard disk drive, a Compact Disc (CD), a Digital Video Disk (DVD), a digital tape, memory, etc. In some implementations, the signal bearing medium **702** can be a computer recordable medium **708**, such as, but not limited to, memory, read/write (R/W) CDs, R/W DVDs, etc. In some implementations, the signal bearing medium **702** can be a communications medium **710**, such as, but not limited to, a digital and/or an analog communication medium (e.g., a fiber optic cable, a waveguide, a wired communications link, a wireless communication link, etc.). Thus, for example, the signal bearing medium **702** can be conveyed by a wireless form of the communications medium **710**.

The one or more programming instructions **704** can be, for example, computer executable and/or logic implemented

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instructions. In some examples, a computing device is configured to provide various operations, functions, or actions in response to the programming instructions 704 conveyed to the computing device by one or more of the computer readable medium 706, the computer recordable medium 708, and/or the communications medium 710.

The non-transitory computer readable medium 706 can also be distributed among multiple data storage elements, which could be remotely located from each other. The computing device that executes some or all of the stored instructions can be a microfabrication controller, or another computing platform. Alternatively, the computing device that executes some or all of the stored instructions could be remotely located computer system, such as a server.

#### IV. CONCLUSION

It should be understood that arrangements described herein are for purposes of example only. As such, those skilled in the art will appreciate that other arrangements and other elements (e.g., machines, interfaces, functions, orders, and groupings of functions, etc.) can be used instead, and some elements may be omitted altogether according to the desired results. Further, many of the elements that are described are functional entities that may be implemented as discrete or distributed components or in conjunction with other components, in any suitable combination and location.

While various aspects and embodiments have been disclosed herein, other aspects and embodiments will be apparent to those skilled in the art. The various aspects and embodiments disclosed herein are for purposes of illustration and are not intended to be limiting, with the true scope and spirit being indicated by the following claims, along with the full scope of equivalents to which such claims are entitled. It is also to be understood that the terminology used herein is for the purpose of describing particular embodiments only, and is not intended to be limiting.

Where example embodiments involve information related to a person or a device of a person, some embodiments may include privacy controls. Such privacy controls may include, at least, anonymization of device identifiers, transparency and user controls, including functionality that would enable users to modify or delete information relating to the user's use of a product.

Further, in situations in where embodiments discussed herein collect personal information about users, or may make use of personal information, the users may be provided with an opportunity to control whether programs or features collect user information (e.g., information about a user's medical history, social network, social actions or activities, profession, a user's preferences, or a user's current location), or to control whether and/or how to receive content from the content server that may be more relevant to the user. In addition, certain data may be treated in one or more ways before it is stored or used, so that personally identifiable information is removed. For example, a user's identity may be treated so that no personally identifiable information can be determined for the user, or a user's geographic location may be generalized where location information is obtained (such as to a city, ZIP code, or state level), so that a particular location of a user cannot be determined. Thus, the user may have control over how information is collected about the user and used by a content server.

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The invention claimed is:

1. A method comprising:

forming a first bio-compatible layer, wherein the first bio-compatible layer defines a first side of a bio-compatible device;

forming a conductive pattern on the first bio-compatible layer, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects;

forming a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer;

mounting an electronic component to the electrical contacts;

forming a second bio-compatible layer over the first bio-compatible layer, the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects, wherein the second bio-compatible layer defines a second side of the bio-compatible device;

removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer; and

removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes.

2. The method of claim 1, wherein the first and second bio-compatible layers comprise paralyne.

3. The method of claim 1, wherein the opening has a dimension between 500 to 700 micrometers.

4. The method of claim 1, further comprising:

forming a sacrificial metal layer on a working substrate, wherein the first bio-compatible layer is formed on the sacrificial metal layer; and

removing the sacrificial metal layer to release the bio-compatible device from the working substrate.

5. The method of claim 4, wherein the sacrificial metal layer comprises at least one metal layer that adheres to the working substrate.

6. The method of claim 4, wherein the sacrificial metal layer further comprises at least one metal layer that bonds to the first bio-compatible layer.

7. The method of claim 4, wherein removing the sacrificial metal layer to release the bio-compatible device from the working substrate comprises dissolving the sacrificial metal layer in a fluid.

8. The method of claim 1, wherein removing a portion of the second bio-compatible layer to form an opening in the second bio-compatible layer comprises:

forming an etch mask over the second bio-compatible layer, wherein the etch mask exposes the portion of the second bio-compatible layer; and

etching, using an inductively coupled plasma, the portion of the second bio-compatible layer exposed by the etch mask to thereby form the opening.

9. The method of claim 8, wherein the etch mask defines a shape of the bio-compatible device.

10. The method of claim 8, wherein the etch mask defines a shape of the antenna.

11. The method of claim 8, wherein removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes comprises: etching, using the inductively coupled plasma, at least a portion of the protective layer through the opening in the second bio-compatible layer.

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12. The method of claim 1, wherein removing the protective layer through the opening in the second bio-compatible layer to thereby expose the sensor electrodes comprises: dissolving at least a portion of the protective layer in a fluid.

13. The method of claim 1, wherein forming a conductive pattern on the first bio-compatible layer comprises: forming a seed layer over the first bio-compatible layer; forming a first sacrificial layer over a portion of the seed layer; forming a first metal layer over portions of the seed layer not covered by the first sacrificial layer, wherein the first metal layer defines the antenna, the electrical contacts, and at least one electrical interconnects of the one or more electrical interconnects; removing the first sacrificial layer; removing portions of the seed layer not covered by the first metal layer; forming a second sacrificial layer over a portion of the first bio-compatible layer and a portion of the first metal layer; forming a second metal layer over portions of the first bio-compatible layer and portions of the first metal layer not covered by the second sacrificial layer, wherein the second metal layer defines the sensor electrodes and at least one electrical interconnects of the one or more electrical interconnects; and removing the second sacrificial layer.

14. The method of claim 1, wherein mounting an electronic component to the electrical contacts comprises bonding the electronic component to the electrical contacts using anisotropic conductive paste.

15. The method of claim 1, further comprising: treating a surface of the first bio-compatible layer, such that a surface of the second bio-compatible layer bonds to the surface of the first bio-compatible layer during formation of the second bio-compatible layer.

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16. The method of claim 15, wherein treating the surface of the first bio-compatible layer comprises treating the surface of the first bio-compatible layer with an inductively coupled plasma.

17. A device comprising:  
 a conductive pattern, wherein the conductive pattern defines an antenna, sensor electrodes, electrical contacts, and one or more electrical interconnects;  
 a protective layer over the sensor electrodes, such that the sensor electrodes are covered by the protective layer, wherein the protective layer comprises one or more photoresist layers;  
 an electronic component mounted to the electrical contacts; and  
 a bio-compatible layer over the electronic component, the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects, such that the antenna, the protective layer, the electrical contacts, and the one or more electrical interconnects are covered by the bio-compatible layer, wherein the bio-compatible layer defines a first side and a second side of a bio-compatible device.

18. The device of claim 17, wherein a portion of the bio-compatible layer can be etched by an inductively coupled plasma to form an opening in the bio-compatible layer.

19. The device of claim 18, wherein the protective layer can be removed through the opening in the bio-compatible layer to thereby expose the sensor electrodes, and wherein at least a portion of the protective layer can be etched by the inductively coupled plasma.

20. The device of claim 18, wherein the protective layer can be removed through the opening in the bio-compatible layer, by dissolving the protective layer in a fluid, to thereby expose the sensor electrodes.

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